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**Cover micrograph**

HAADF-STEM image of Y-doped $\Sigma 31$ [0001] tilt grain boundary in alumina, taken with JEM-2100F with Cs corrector (top) and an electron density map around Y atoms segregated in $\Sigma 31$ Al$_2$O$_3$ grain boundary, obtained by the first principles calculation (bottom). (See page 4)

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**Interface Studies by Cs-Corrected STEM**

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**Introduction**

Grain boundaries and interfaces of crystals have peculiar electronic structures, caused by the disorder in periodicity, providing the functional properties, which cannot be observed in a perfect crystal [1, 2]. In the vicinity of the grain boundaries and interfaces around the order of 1 nanometer, dopants or impurities are often segregated, and they play a crucial role in the material properties. We call these dopants “function providing elements”, which have the characteristics to change the macroscopic properties of the materials drastically.

To obtain a guideline for designing material by the atomic scale modification, an understanding of the atomistic mechanism for the functional properties is required as well as precise measurement of the state of trace elements segregated in the nanoscale region. In recent nano-characterization technologies, there has been remarkable progress by Scanning Transmission Electron Microscopy (STEM) utilizing the spherical aberration (Cs) corrector [3]. The technique enables us not only to identify the location of the dopants but also to analyze the local electronic state for the single atomic column on grain boundaries and interfaces. In this paper, we focus our attention on grain boundaries and interfaces of various ceramics, to which “function providing elements” are doped, and introduce our latest results of the microstructure analysis by STEM. Furthermore, by the first principles calculation based on these observation results, the mechanism of the “function providing elements” will be described as well.

**Scanning Transmission Electron Microscopy (STEM)**

STEM is a technique to scan a specimen by an electron probe, which is focused down to 1 nm or less on the sample. The STEM image is formed with the collected scattered electrons in each probe position by the Annular Dark Field (ADF) detector at the bottom of the sample on the monitor in synchronism with the scanning probe [4]. The atomic resolution image can be obtained by focusing the electron probe down to below the atomic column interval. The advantages of this method are those: there is no inversion of the image contrast with the defocusing and the change in the sample thickness, and thus the positions of the atomic columns can be determined directly from the image. These excellent characteristics are very useful to determine the complicated atomic structures in the grain boundaries and interfaces. In addition, the intensity of the image obtained by detecting the electrons scattered to higher angles is known to correspond to approximately the square of the atomic number Z. The contrast of High Angle Annular Dark Field (HAADF)-STEM is therefore called “Z-contrast” as well, making it possible to observe the element distribution at an atomic column level in the region where local composition is changed. **Figure 1** shows an example of HAADF-STEM image for SrTiO$_3$ projected along the [001]. As seen in Fig. 1, the contrast of Sr atoms (Z=38) is brighter than that of Ti atoms (Z=22), which indicates that atomic species can be discriminated in the one image. Moreover, in recent years, by combining STEM method with the Cs correction technology, drastic improvement in resolution has become possible. At present, with the STEM using the Cs corrector, the electron probe diameter of 0.1 nm or less has been already...
achieved [5]. Furthermore, since the intensity of the electron probe can be increased by the Cs correction technology, there are advantages that the S/N ratio of the STEM image will be increased and hence the image quality also can be improved drastically. STEM method using the Cs corrector is thus expected as a powerful tool to characterize the atomic structures in grain boundaries and interfaces.

**Grain Boundary of Pr-doped ZnO Varistor**[6, 7]

As an example of the grain boundary segregation in electroceramics, Pr doped ZnO grain boundary is shown in this section. Since ZnO ceramics show high nonlinear current-voltage characteristics by doping secondary elements such as Pr and Bi, they are widely used for varistors. It has been reported that Pr and Bi etc., doped to ZnO ceramics segregate in grain boundaries and it is believed that they have an important role for providing varistor properties. However, their segregation behaviors have not been understood in detail at an atomic level. It is therefore required to characterize an atomic level analysis of the Pr segregation in ZnO grain boundaries to clarify the atomistic mechanism of the varistor properties.

**Figure 2** shows a HAADF-STEM image of the Pr-doped Σ7 grain boundary (JEOL JEM-2100F (200 kV) with Cs corrector (CEOS), Univ. Tokyo) [6]. Here, Σ represents the degree of geometrical coherency at grain boundaries [1]. The small Σ number indicates high coherency, and the large Σ number indicates low coherency at grain boundaries. As described above, in HAADF-STEM image, the atomic column position emerges as white dots. Pr that has the higher atomic number than Zn, shows the brighter contrast. Accordingly, the
bright spots, indicated by the arrows at the grain boundary, show the segregated Pr atoms. It can be recognized from the image that Pr does not have the wide distribution but segregates only at the special atomic sites. With substituting Pr atoms, suggested from the HAADF-STEM image, to the Zn sites in the Σ7 grain boundary, the most stable atomic structure was calculated by the first principles method as shown in Fig. 3 [7]. It is confirmed from Fig. 3 that the experimentally observed Pr atoms segregate to the most stable positions in the grain boundary. In addition, by the systematic first principles calculations, it was found that due to Pr presence in the grain boundary, acceptor type defects such as Zn vacancy and interstitial O atom are easily formed as well [6, 7]. These defect formations must be related with the mechanism of the varistor properties, which is believed to be an important role of Pr addition. Furthermore, it has been shown by the similar calculations that Pr segregates preferentially at the Zn sites (the locally tensile sites), in which the bonding length at the grain boundary is long [7].

**Grain Boundary of Y-doped Alumina Ceramics** [8]

It has been known that the high temperature strength of alumina ceramics is improved drastically by doping small amount of rare earth elements such as Y and Lu [8, 9]. Although it has been proposed that these minor doping elements segregate in the grain boundaries in the alumina polycrystal and prevent grain boundary sliding at high temperature, there are many unknown issues regarding the intrinsic mechanism yet. Here, the grain boundary structure of the Y-doped alumina was observed by STEM method. The results demonstrate the grain boundary strengthening mechanism by Y. Figure 4 shows HAADF-STEM image of the Y-doped Σ31 alumina grain boundary (JEOL JEM-2100F (200 kV) with Cs corrector (CEOS), Univ. Tokyo) [8]. Here, Σ31 grain boundary can be classified into a general grain boundary. It can be recognized that very strong contrast is observed at the particular atomic sites along the grain boundary. It corresponds to the position of Y atoms segregated in the grain boundary cores, which indicates that Y atoms segregate selectively and periodically only at the special sites in the grain boundary cores. Figure 5 shows the results of the theoretical analysis by the first principles calculation based on this structure, showing the electron density distribution around the Y atoms segregated in the center of the seven member ring [8]. From Fig. 5, it is recognized that the electron distribution is oriented around Y atoms to form covalent-like chemical bonds in the seven member ring, which is confirmed to be significant by comparing with the fact that the bonds without segregation are mainly ionic bonding [8]. In this way, it has become evident that due to the segregation of rare earth elements in the grain boundaries, surrounding chemical bonds change drastically, which has the effect to improve the grain boundary strength. In other words, it is believed that the effect of rare earth element doping to alumina ceramics is originated from the change in the local chemical bonding state at the grain boundary.

**Dislocation Structure of Sapphire** [10]

To understand the mechanical properties of sapphire, many studies have been performed for the dislocations so far. It has been shown that the basal dislocation is dissociated to two partial dislocations. However, there are many unknown matters concerning the structure at the atomic level, and the atomistic mechanism of dislocation glide has not been quantitatively understood yet. Since sapphire is composed of Al and O, an analysis of sublattice including the oxygen is required to understand its dislocation core structure at the atomic level. Therefore, using the Cs-corrected STEM, the dislocation core structure including the oxygen column was directly observed by combining BF and HAADF-STEM techniques.

Figure 6 shows (a) the crystal structure model of sapphire crystal viewed from [1100] direction, (b) the HAADF-STEM and (c) the Bright Field (BF) STEM images (VG HB603U STEM (300 kV) with Cs corrector (Nion), ORNL) [10]. By STEM, the BF and the HAADF image can be obtained from the same area simultaneously. As shown in the
crystal structure model, the atomic columns of Al and O can be distinguished with the present incident axis. In the HAADF-STEM image shown in (b), the positions of the O columns and the Al columns are apparently discriminated. Although the S/N ratio of the HAADF-STEM image is lower than the one of the BF-STEM image of (c), the atom position can be determined directly, since the image is the image under incoherent conditions. On the other hand, the S/N of the BF-STEM image is pretty high, and the BF-STEM image is optically equivalent to the image obtained by high-resolution transmission electron microscopy (HRTEM) due to the reciprocity theorem. Although, the contrast of BF-STEM image varies widely according to the defocusing and the thickness of the sample, accordingly, by taking the BF-STEM image and the HAADF-STEM image simultaneously to compare their contrast, the correspondence of the contrast of the BF-STEM image and the atom position can be determined directly. Under the present observation condition, the position of the bright contrast in the BF-STEM image directly corresponds to the atomic column position. The structure determination including so far as the light element like oxygen thus becomes possible by simultaneous observation utilizing the image formation by both HAADF and BF STEM imaging.

The basal dislocation of sapphire has the Burgers vector of \( \mathbf{b} = \frac{1}{3} <11\overline{2}0> \), but it has been confirmed that the dislocation core is dissociated by climb mechanism along the [0001] direction and is composed of partial dislocations of \( \mathbf{b}_1 = \frac{1}{3} <01\overline{1}0> \) and \( \mathbf{b}_2 = \frac{1}{3} <10\overline{1}0> \) and stacking faults on the \{11\overline{2}0\} plane [11].

Figure 7 shows the BF-STEM image of each dislocation edge of the dissociated partial dislocations (VG HB603U STEM (300 kV)). In the BF-STEM image, since the oxygen column
and the aluminum column can be identified, the atomic columns at the dislocation edge can be directly determined. As apparent from the experimental image, two partial dislocations terminate at the aluminum and the oxygen atomic columns, respectively. It is thus shown that each partial dislocation core has the structure with local composition shift of aluminum surplus or oxygen surplus from the stoichiometric ratio.

In case of ionic crystals, although the structure like this has been considered to be energetically unstable, the present results first demonstrate that the nonstoichiometric local structure can exist in the crystal. If the perfect dislocation is composed of two partial dislocations, the stoichiometric ratio is satisfied in total. In other words, the stoichiometry is maintained when the basal dislocation glides. By the direct observation of the dislocation core structure like this, the gliding mechanism of the basal dislocation of sapphire can be understood [10], which will bring a great breakthrough to the study of ceramics dislocations, the stoichiometric ratio is satisfied in total. In other words, the stoichiometry is maintained when the basal dislocation glides.

Interface Structure of SrTiO₃/Nb-SrTiO₃/SrTiO₃ Superlattice[13]

It has been known that some oxide superlattices can be used as thermoelectric device. For example, a high-density two-dimensional electron gas confined within a unit cell layer thickness (0.3905 nm) in SrTiO₃ exhibits high thermoelectric properties, which is about 5 times larger than that of the bulk SrTiO₃ [13].

Figure 8 shows HAADF-STEM image of the SrTiO₃/Nb-doped SrTiO₃/SrTiO₃ superlattice film (JEOL JEM-2100F (200 kV) with Cs corrector (CEOS), Univ. Tokyo) [13]. As described above, it is recognized that Sr (Z=38) columns are observed brightly compared with the Ti (Z=22) columns in SrTiO₃. In this case, Nb-doped SrTiO₃ layers are observed at every 24 unit cell as stripe contrast (Fig. 8(a)). Figure 8(b) and (c) show the magnified HAADF-STEM image around the Nb-doped SrTiO₃ layer and a line profile of the image intensity of the Sr atomic row and the Ti atomic row in the same region. From these figures, it is recognized that the image intensity does not change in the Sr atomic row; however, the image intensity becomes high in the Ti atomic row at the Nb-doped SrTiO₃ layer. Taking into consideration that the atomic number of Nb is 41, it is considered that Nb exists at the Ti sites by substitution. On the other hand, since the atomic numbers of Nb and Sr are close, whether Nb exists in the Sr sites or not cannot be judged only by the contrast of the HAADF-STEM image. Then, the solution energy of Nb was calculated by the first principles PAW (Projector Augmented-Wave) method. It is then clarified that the solution energy of Nb to the Sr sites is 7.6 eV higher compared with the one to the Ti sites. This result also shows the solubility of Nb to the Ti sites.

Figure 9 shows the spectra of Ti-L₂₃ ELNES (Energy Loss Near Edge Structure) obtained from the SrTiO₃ layer and the Nb-doped SrTiO₃ layer in the SrTiO₃/Nb-doped SrTiO₃/SrTiO₃ superlattice. The upper figure corresponds to the experimental spectra, and the bottom figure corresponds to the theoretically calculated spectra. Although four peaks (l₂g, e₂g split) are apparent in the spectra obtained from the SrTiO₃ layer, it is recognized that the peaks are broadened in the spectrum from the Nb-doped SrTiO₃ layer. Comparing the theoretical ELNES calculated by the first principles relativistic multi-electron method with the experimental ELNES, it is found that the change in the experimental spectra is due to the transition from Ti³⁺ to Ti⁴⁺ which is accompanied by the Nb doping.

Direct Observation of Li ion site in lithium battery[14]

Li battery is widely used for the battery of cellular phone and personal computer. Recently, it is also intensively studied for the application of the automobile battery. The properties of Li battery is strongly dependent on the positive electrode active material, and cobalt or nickel-compounds such as LiCoO₂ or LiNiO₂ have been mainly used as the positive electrode products so far. However, it has been pointed out that they have problems on the stability, lifetime and reliability. LiFePO₄ with the stable olivine structure is therefore expected as the lithium battery for the next generation. Since the properties of the positive electrode active material is related to the behavior of Li ions in the crystal, direct visualization of Li site is needed to understand the mechanism of the properties. But, it is impossible to directly observe Li atoms even by HAADF-STEM technique because the atomic number 3 for Li is too small to scatter electrons. We therefore exchanged a part of Li sites with Fe atoms in...
LiFePO₄ crystal by chemical modification-annealing technique, and tried to directly observe the Li sites by HAADF-STEM. Figure 10 shows HAADF-STEM image for the LiFePO₄ crystals observed along the [010] direction (JEOL JEM-2100F (200 kV) with Cs corrector (CEOS), Univ. Tokyo). In the sample, about 15% of Li sites were substituted by Fe atoms [14]. In Fig. 10, the model crystal structure composed of Fe, Li, P, O is shown, and the inset shows the simulated HAADF image for the olivine with 15% Li-Fe exchange. As can be seen in the image, Li sites, which is substituted by Fe atoms, can be observed as weak spots in the center of hexagonal framework composed of Fe and P. It is also found that such exchange defects appear to be locally aggregated rather than homogeneously dispersed in the crystal. In addition, the distribution of the exchange defect was not homogeneous in the vicinity of the grain boundaries, which indicates that the direct visualization of Li sites will clarify the behavior of lithium ions, conductor and breakdown mechanism of lithium battery in the future.

Conclusion

Various kinds of dopants have been used for industrial materials to improve the functional and mechanical properties. However, many of such dopants have been considered and selected on the basis of the long-term experience and empirical background, and it is hence unclear for the effect of the function providing dopants on the atomistic mechanism. If the atomistic mechanism can be fully understood, it will be possible to reasonably design material by controlling atoms, electrons and function providing elements in the materials. The appearance of Cs corrected STEM enables us to determine the location of the dopants and the local electronic state at a single atom level.

In this paper, we introduced our recent results obtained for ceramic grain boundary and interface by Cs corrected STEM. Several examples are demonstrated for the gain boundaries of varistor and structural ceramics, dislocation in alumina, oxide superlattice, lithium battery and so on. These results indicate that the atomistic mechanism of the properties can be unraveled by the combination of STEM characterization and the first principles calculations. This approach must be a breakthrough for new materials science and engineering in the next generation.

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References

Field Emission AES Characterization of Corrosion Products Formed on Copper in Chloride Containing Solutions

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During the first 24 h of immersion of a pure copper surface in a NaCl containing solution, this surface is in constant evolution. The reactions going on the surface are still not known; discrepancies are found between different studies published. This work uses Field Emission Auger Electron Spectroscopy to localize and identify the reaction products that can be formed on copper surfaces in this type of environments. Identification was based on identification of elements. A more profound analysis of the compounds present on the surface was performed by applying Target Factor Analysis on the recorded spectra.

Introduction

The first 24 hours it is immersed in a 0.5 M NaCl solution, a copper surface undergoes a series of transformations. A corrosion product layer is formed that acts as a barrier layer between the aggressive solution and the substrate, offering some protection to the material. This barrier layer itself is subsequently attacked and localized corrosion is observed. The evolution can be divided into three stages. In the first hour, a homogeneous corrosion layer is formed over the entire surface. In the next hours, the thickness of this layer keeps on increasing. After two hours local corrosion starts to appear, piercing the formerly grown oxide layer in certain places. This attack is localized mostly at the grain boundaries. After 20 hours of immersion almost all these local attack sites gradually get covered anew by the constantly growing corrosion product layer. Electrochemical Impedance Spectroscopy (EIS) studies conducted on these surfaces generate a response that is a combination of the response of both reactions, making it impossible to discriminate between global and local reaction properties [1,2]. Knowing the reaction products present on different parts of the surface would however represent a great deal of information if one needs to identify the reactions taking place on this surface.

Extensive studies have already been carried out on these surfaces, but still some lack of clarity remains, illustrated by some yet unidentified features in electrochemical impedance spectra (EIS) recorded on these surfaces [1,2,3]. From the various works it becomes clear that multiple species have been identified to form on the surface. Among them Cu$_2$O [4-8] CuCl [5,6,8,9-13] or CuO [14-19]. Auger spectroscopy was already used in various works dedicated to the study of copper corrosion. A number of papers has been published on the identification of copper oxides, formed on various substrates [20-23]. Also a limited amount of literature exists on the identification of copper chlorides [24]. Lineshape analysis was used in a number of works as a tool to discriminate between different copper compounds, concentrating however on thermally formed oxides and chloride compounds grown in modified vacuum conditions. The study presented in this work uses Field Emission AES (FE-AES) to identify different copper compounds on the same surface. All of these were formed during the corrosion process of copper in aqueous chloride containing solutions. Lateral distributions of the composition were visualized by Auger imaging. Identification of the compounds was done by comparing the recorded high resolution FE-AES spectra on corroded surfaces with spectra obtained from reference materials. With the acquired reference spectra Target Factor Analysis (TFA) was carried out to analyze the chemical composition of the corrosion products. Both the in-depth product distribution in the uniform corrosion layer and the distribution of the products in and around a local corrosion site were studied.

Experimental

Surface analysis was done using a JEOL JAMP-9500F scanning Auger microprobe. Settings were such that an electron beam of 10 kV and 1 nA at an angle of incidence of 30° with respect to the sample surface normal was applied. Measurements were performed using an energy resolution dE/E of 0.06 %. The spectra during depth profiles and line profiles were obtained using a step of 0.1 eV. When carbon was detected at the surface, the materials were sputtered with the attached ion gun for several seconds using 1 keV Ar$^+$-ions in order to remove the impurities. Depth profiles were obtained using 1 keV Ar$^+$-ions. The ion gun was calibrated on Ta/Ta$_2$O$_5$ samples and had a sputter rate of 3nm/min. The spectra were corrected for the work function of the equipment (ef = 4.5 eV). Signal intensities were calculated by subtracting the peak signal from the background signal in the direct spectrum.

SEM images were obtained using the secondary electron detector attached to the FE-AES.

Chemical reagent products from different producers were used as reference materials: Pro Analyysi CuO from Merck, 99.99 % pure Cu$_2$O from Aldrich and Pro Analyysi CuCl from Merck. All were under the form of small crystals or powder. The reference material samples were obtained by pressing the powder or crystals into very soft polished Electrolytic Tough Pitch (ETP) copper obtained from Cumerio (Olen BE). Reference spectra of copper were obtained from the very pure ETP copper.

The material studied was a 99.9 % pure copper, obtained from Goodfellow. Samples were cut from a 20.6 mm diameter rod. Prior to attack the samples were prepared by a metallurgical procedure [25]. This was polishing subsequently with 320 grit SiC paper, 9 and 3µm diamond paste and finally 0.04 µm colloidal silica.

The samples were immersed in 0.5 M NaCl solutions for various periods of time. The solvent was deionized and non-deaerated water.
Results and Discussion

Cu LVV spectra on different copper compounds are shown in Figure 1. The analysis of the compounds present on the corroded copper surface was based on reference spectra obtained from various reference materials, as mentioned in the experimental part. The spectra presented here were subsequently used in the TFA procedures applied to derive the chemical composition in different points on the surface. It was chosen to perform the TFA analysis using the Cu spectra as this element is the only one present in all compounds expected to be found on the surface. Besides, these spectra showed also the most visible difference in peak shape when comparing different compounds.

The spectrum of pure copper is the sharpest, presenting 4 distinguishable contributions in the energy window of interest. The copper chloride presents the broadest peak found. Both copper oxides generate a single peak contribution, somewhat broader than the pure copper main peak, but with a maximum at clearly different energy positions.

Figure 2 a and b show a SEM image of the copper surface after 1 and 3 hours of immersion in the 0.5 M NaCl solution. Images of copper surfaces formed after different times of immersion show the same tendency: the surface undergoes local and global attack at the same time. Global attack creates a corrosion product layer, somewhat porous in nature. Local attack is more severe and creates holes in the surface. In these holes also a corrosion product layer is formed. Depth profiles recorded on both types of location show that the general corrosion layer is thicker than the one formed inside local attack sites.

Figure 3 shows the thickness of the general...
corrosion product layer formed after different immersion times in the NaCl solution. From the evolution, it can be concluded that the layer thickness increases with time. Also a high resolution depth profile was recorded on a corroded copper surface. Figure 4 shows the evolution of the composition evolution resulting from a depth profile obtained from the general corrosion layer. This layer was formed on a copper surface immersed during 7 hours in the chloride containing solution. From this figure it is clear that, in the general corrosion product layer, chloride is only present in the outermost layers. Deeper in the layer only copper and oxygen can be identified. After sputtering for a longer time, also the oxygen signal intensity decreases to zero.

Figure 5 shows the results of the TFA analysis performed on the Cu LVV spectrum recorded in the depth profile of Figure 4. As mentioned before, the spectra shown in Figure 1 were used as factors in this analysis. From the calculations it became clear that the corrosion product layer can be divided into 3 zones, as indicated on the figure. Most of the layer is represented by zone III. This zone, situated closest to the pure metal, consists of mostly Cu₂O, but CuO can be found as well. Above this zone, a zone with a very high CuO content is found. Zone I, the outermost layer, knows a very high content of copper chlorides. This is in line with the composition depth profile in Figure 4 and indicates the reliability of the TFA analysis performed.

Over the entire thickness of the corrosion product layer also a pure Cu contribution is present. This presence is attributed to the porous nature of the corrosion product layer. A more detailed study of the lateral distribution of corrosion products over the surface was performed by recording spectrum line profiles that span global corrosion layers as well as local attack sites. The intensity line profile on a copper surface after 6 hours of immersion in the 0.5 M NaCl solution as well as the location where it was recorded can be found in Figure 6. To remove carbon contamination from the surface, a light sputtering was applied to the surface before performing the measurement. This treatment however also removed the very thin layer of copper chloride components that was present on the surface. Depth profiles performed on this sample showed that less chlorides were present than on the sample in figure 4, as the immersion time was shorter. The line profile shows nevertheless the presence of higher concentrations of chlorides in and around local attack sites.

The results of the TFA analysis performed on the Cu LVV spectrum recorded in this experiment are shown in Figure 7. In points on the general corrosion layer on the surface only 2 contributions can be identified by the analysis: a major contribution of Cu₂O and a less prominent amount of CuO. The places where local corrosion has taken place are indicated by an arrow in Figure 6. In these locations the composition differs significantly from the one at the general corrosion layer.

A first observation is the dominating presence of a pure copper contribution at the edges of the local attack sites. This can be attributed to the high speed nature of the local attack, resulting in the formation of very thin layers of corrosion products at these locations. In the local attack sites copper chloride compounds are found as well, as could be expected from the composition line profile shown in Figure 6. CuO and Cu₂O are also present in the local attack sites. The relation between both compounds differs however from the one on the surrounding general corrosion product layer. In the sites indicated by the arrows, the contribution of CuO is more dominant, while the Cu₂O concentration is lower. This confirms again that corrosion products formed during global and local corrosion reactions differ substantially.

Conclusions

This work describes the study of corrosion products formed on commercially pure copper after immersion in chloride containing solutions. This was done using FE AES combined with a TFA analysis. In these solutions global corrosion as well as local attack reactions take place on the same surface. The more profound analysis of the composition of the general corrosion product layer learned that this porous layer consists of copper chlorides as well as oxides. The TFA analysis of this layer showed that it can be divided into 3 zones. The outermost zone consisted mainly of copper chlorides. Cu₂O was the oxide that was most prominently present in the corrosion product layers. CuO could also be found, being the most prominent compound right underneath the chloride rich layer. The porosity of the layer resulted in a permanent pure copper contribution throughout the layer.

The places where localized corrosion occurred showed a different composition. In these positions more chlorides were detected than in the surrounding areas. Also CuO was present more prominently than Cu₂O in these places. A combination of the observations led to the conclusion that the corrosion reaction products formed during local attack and global corrosion reactions differ substantially. The results of this study, the identification of the corrosion products, will be combined with electrochemical investigations to enable the identification of the corrosion reactions taking place on the studied locations.

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References


Mg-based alloys containing rare earth elements have been paid much attention as industrial materials, because of their low density and high recyclability. High strength of the Mg-based alloys is performed using precipitation hardening by aging of supersaturated solid solutions of the alloys at low temperatures. Magnesium-based alloys containing rare earth elements such as Y, Gd, Nd, and Dy have a wide solubility at high temperatures and a very narrow solubility at low temperatures. Therefore, by aging of supersaturated solid solutions of Mg-RE (RE: rare earth metals) alloys, prepared by quenching from high temperatures and a very narrow solubility at low temperatures, and so it is important to elucidate microstructures of precipitates. We have studied structures of fine precipitates in Mg-Gd, Mg-Y and Mg-Gd-Zn alloys by the combination of HRTEM and HAADF-STEM, and obtained some valuable information, which can not be accomplished by only HRTEM or HAADF-STEM. In this paper, we review recent results about crystal structures and morphology of precipitates in the Mg-Gd, Mg-Y and Mg-Gd-Zn alloys.

Introduction

Utilization of Mg-based alloys is spreading in automotive, aerospace and electronic industries, because of their low density and high recyclability. High strength of the Mg-based alloys is performed using precipitation hardening by aging of supersaturated solid solutions of the alloys at low temperatures. Magnesium-based alloys containing rare earth elements have been paid much attention as industrial materials, because of their low density and high recyclability. These alloys show remarkable precipitation hardening by aging of supersaturated solid solutions at low temperatures, and so it is important to elucidate microstructures of precipitates. We have studied structures of fine precipitates in Mg-Gd, Mg-Y and Mg-Gd-Zn alloys by the combination of HRTEM and HAADF-STEM, and obtained some valuable information, which can not be accomplished by only HRTEM or HAADF-STEM. In this paper, we review recent results about crystal structures and morphology of precipitates in the Mg-Gd, Mg-Y and Mg-Gd-Zn alloys.

Experimental Procedure

Mg-RE(-Zn) alloys were prepared by melting construction metals by high frequency induction heating under an Ar gas in carbon crucibles. The alloys were homogenized at 520 °C for 2 hrs and then quenched in water, and finally were aged at 200 °C. TEM specimens were cut from the alloys, and thinned by mechanical polishing and finally by ion-milling. TEM and HRTEM observations were performed by a 400 kV electron microscope (JEOL JEM-4000EX) with a resolution of 0.17 nm, and HAADF-STEM images were taken by a 300 kV electron microscope (JEOL JEM-3000F) equipped with a field emission gun in the scanning transmission electron microscope mode. In HAADF-STEM observations, a beam probe with a half width of about 0.2 nm was scanned on samples.

Short-range ordering in the early stage of aging in Mg-Gd alloy

Diffuse reflections in electron diffraction patterns have been found in the early stage of aging for many Mg-RE alloys, as can be seen in Figure 1(a) that is an electron diffraction pattern of the Mg-5at%Gd alloy aged at 200 °C for 5 hrs, taken with the incident beam parallel to the [001]m direction of the Mg-matrix. Diffuse reflections are observed at 1/2 0 0-typed positions between strong reflections of an Mg-hexagonal lattice. Since the 1/2 0 0-typed positions correspond to ones of superlattice reflections of the D0₅ (Mg,RE) structure, the diffuse reflections have been considered to result from fine precipitates of the Mg,RE phase.

Figures 1(b) and (c) show HRTEM and HAADF-STEM images, respectively, corresponding to the diffraction pattern of Fig. 1(a). Structural modulations producing the diffuse reflections in Fig. 1(a) are represented as weak and fine contrast modulations in lattice fringes of the Mg-matrix in the HRTEM image of Fig. 1(b), but it is impossible to elucidate structural modulations from Fig. 1(b). On the other hand, the HAADF-STEM image of Fig. 1(c) can reproduce individual Gd atoms, projected along the incident beam, as bright dots without the disturbing of the Mg-matrix. Contrasts of the bright dots correspond to occupation probabilities of Gd atoms in atom columns along the incident beam, and arrangements of bright dots show those of Gd atoms projected along the incident beam. The arrangement of the bright dots in Fig. 1(c) indicates a short-range ordered state without the existence of fine precipitates with periodic arrangements in wide regions. The bright dots are mainly arranged with an interval of about 0.37 nm, which corresponds to a second nearest neighbor distance in a hexagonal close-packed (hcp) structure, and form characteristic local arrangements such as hexagonal arrangements indicated by arrows and zigzag lines with an interval of about 1.1 nm, indicated by arrowheads. The hexagonal arrangement of Gd atoms can be seen in the D0₅ structure, which is formed by ordering of Gd atoms located at second nearest-neighbor positions in the hcp structure, as shown in Figure 2(c). In the D0₅ structure, the ordering...
of Gd atoms forms a hexagonal arrangement with a side length of \((2a_0\sqrt{3})/3=0.37\) nm, where \(a_0\) is a lattice parameter of a Mg hexagonal lattice, as can be seen in Fig. 2(c). The zigzag lines with an interval of 1.1 nm correspond to those of Gd atoms with an interval of \(2a_0\sqrt{3}\) in the Mg\(_7\)Gd structure of the \(\beta'\) phase, as shown in Fig. 2(b). That is, nuclei of the Mg\(_7\)Gd structure occur in the short-range ordered state by aging at 200 °C for 5 hrs.

The present observations clearly verify that precipitates of a \(\beta'\) phase with a D\(0_1\) structure, proposed by many previous papers [6-9], do not exist in the early stage of aging, showing diffuse reflections in electron diffraction patterns, and that a short-range ordered state in Gd-enriched regions is formed and nuclei of the Mg-Gd structure occur in the short-range ordered region.

**Crystal structure of the \(\beta'\) phase**

The \(\beta'\) phase of an ordered structure with an orthorhombic unit precipitates in many Mg-RE alloys aged at a peak hardness condition. **Figure 3** shows an HAADF-STEM image of the \(\beta'\) phase in the Mg-5at% Gd alloy aged at 200 °C for 100 hrs, taken with the incident beam parallel to the c-axis of the orthorhombic structure. The deformation of a unit cell indicated by white lines from a rectangle in Fig. 3 results from the sample drift during scanning of the incident beam. In the image of Fig. 3, zigzag arrays of bright dots along the a-axis are observed. From this image, a structure model of the \(\beta'\) phase can be directly derived as Fig. 2(b). In the model of Fig. 2(b), Gd atoms are arranged with face-centered symmetry in \(z=0\) and \(z=1/2\) planes in an orthorhombic unit cell of \(a=2a_0=0.64\) nm, \(b=4a_0\sqrt{3}=2.22\) nm and \(c=c_0=0.52\) nm, where \(a_0\) and \(c_0\) are lattice constants of a hexagonal unit of the Mg-matrix. In the atomic arrangement of Fig. 2(b) projected along the c-axis, zigzag arrays of Gd atoms, indicated by thick line, along the a-axis correspond to those of bright dots in Fig. 3.

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The structure model has an atomic ratio of Mg:Gd, which shows a good correspondence to a composition of the $\beta'$ phase (88 at% Mg and 12 at% Gd) evaluated by EDS. It should be noted here that the present structural model of the $\beta'$ phase is apparently different from a previous model (Figure 2(a)) proposed by HRTEM observations [14]. As for the atomic arrangement in the $z=0$ plane, both the models are the same, but the $z=1/2$ plane in the previous model is formed by only Mg atoms without any Gd atoms, and so a composition of the previous model becomes Mg$_{15}$Gd. Obviously, the previous model can not explain the zigzag arrays of bright dots in the HAADF-STEM image of Fig. 3 and also the evaluated composition of the $\beta'$ phase (88 at% Mg and 12 at% Gd). We have confirmed that the $\beta'$ phase in an Mg-Y alloy has the same structure as Fig. 2(b) [12].

### Morphology of $\beta'$ precipitates in Mg-Gd and Mg-Y alloys

**Figure 4** is HAADF-STEM images of $\beta'$ precipitates in Mg-5at%Gd (a) and Mg-2at%Y alloys (b), taken with the incident beam parallel to the [001]$_m$ direction of the hexagonal Mg-matrix.

In Fig. 4, one can see three variants of $\beta'$ precipitates with different directions of a- and b-axes, which are equivalent directions in the Mg-hexagonal lattice, and also can notice that morphologies of the $\beta'$ precipitates in Fig. 4(a) and 4(b) are extremely different. In Fig. 4(a), the precipitates with an oval shape, which corresponds to the section of rod-shaped precipitates with a rod-axis along the c-axis, with a long radius along the b-axis and short one along the a-axis are joined along the b-axis. Successive joining of rod-shaped precipitates are performed along the b-axis, and consequently produces planar-shaped precipitates extended over an about 100 nm length along.
Fig. 8 HAADF-STEM images of GP-zones in the Mg-2at%Gd-1at%Zn alloy aged at 200°C for 150 hrs, taken with the incident beam parallel to the [001]m and [100]m directions of the hexagonal Mg-matrix. Dumbbells of two bright dots are periodically arranged along GP-zones in (a), and weak bright dots in (b) are arranged with a hexagonal lattice. The bright dots correspond to Gd and/or Zn atoms projected along the [1-10]m and [001]m directions.

Fig. 7 TEM (a) and HRTEM (b) images of the Mg-2at%Gd-1at%Zn alloy aged at 200°C for 150 hrs, taken with the incident beam parallel to the [1-10]m direction of the hexagonal Mg-matrix. Line contrasts perpendicular to the c-axis in (a) are GP-zones. The HRTEM image of two GP-zones embedded in the Mg-matrix in (b) shows an ordered arrangement of bright and dark dots, with intervals of 2d002 and 3d110 spacings of a hexagonal lattice of the Mg-matrix, in the GP-zones.

Fig. 6 Electron diffraction patterns of the Mg-2at%Gd-1at%Zn alloy aged at 200°C for 150 hrs, taken with the incident beam parallel to the [001]m and [100]m directions of the hexagonal Mg-matrix. 1/3 1/3 0-typed extra reflections indicated by arrows in (a) and streak reflections indicated by arrows in (b) are observed in addition to superlattice reflections of β’ phases between strong reflections indexed by a hexagonal lattice of the Mg-matrix.

Fig. 5 shows HRTEM images of β’ precipitates embedded in the Mg-matrix in Mg-5at%Gd (a) and Mg-2at%Y (b) alloys. Lattice fringes in the β’ precipitates and Mg-matrix are continuously bound up without any interface dislocations. That is, the β’ phases precipitates with being fully coherent to the Mg-matrix. However, a relatively large lattice misfit between the β’ phase and Mg-matrix in the Mg-Gd alloy (Fig. 5(a)) produces lattice distortions in the both crystals. Consequently, the lattice distortions due to the lattice misfit are relaxed by the appearance of dislocations in the β’ precipitates, as indicated by an arrow in Fig. 5(a). On the other hand, a small lattice misfit between the β’ phase of the Mg-Y alloy and Mg-matrix produces no lattice distortions at interfaces between the β’ precipitates and Mg-matrix, and permits individual growth of Y-enriched atomic planes along the a-axis, as considered to result from the difference between lattice parameters of a and b for the Mg-Gd and Mg-Y structures. Lattice parameters of the orthorhombic β’ phase in the Mg-5at%Gd alloy aged at 250°C for 100 hrs were estimated as a=0.650 nm, b=2.272 nm and c=0.521 nm [12], which are remarkable differences from 2a0=0.6418 nm, 4a0=2.232 nm and c0=0.5210 nm. On the other hand, lattice parameters of the orthorhombic β’ phase in the Mg-2at%Y alloy are nearly a=2a0=0.6418 nm and b=4 a0=3=2.2232 nm. Considering the difference in morphologies of the β’ precipitates in Mg-Gd and Mg-Y alloys can be understood by values of lattice misfits between the β’ phases and the Mg-matrix. 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**Guinier-Preston zone in Mg-Gd-Zn alloy**

**Figures 6(a) and (b)** are electron diffraction patterns of the Mg-2at%Gd-1at%Zn aged at 200 °C for 150 hrs, taken with the incident beam parallel to the [001]m and [110]m directions of the hexagonal Mg-matrix, respectively. In the diffraction patterns, 1/3 1/3 0-typed extra spots indicated by arrows in Fig. 6(a) and streak reflections indicated by arrows in Fig. 6(b) are observed in addition to superlattice reflections of β' precipitates between strong reflections of a hexagonal lattice of the Mg-matrix. From the comparison between Fig. 6(a) and Fig. 6(b), it can be concluded that the 1/3 1/3 0-typed extra spots in Fig. 6(a) correspond to sections of the streak reflections in Fig. 6(b), and that the streak reflections in Fig. 6(b) have a rod-shape.

In HRTEM images taken with the incident beam parallel to the [001]m direction of the hexagonal Mg-matrix, the β' precipitates are observed, but precipitates showing the 1/3 1/3 0-typed extra reflections in Fig. 6(a) cannot be recognized.

**Figures 7(a) and (b)** show a TEM and an HRTEM images of the Mg-2at%Gd-1at%Zn alloy, respectively, taken with the incident beam parallel to the [001]m direction of the hexagonal Mg-matrix. Planar faults producing the streak reflections in Fig. 6(b) are observed as line contrasts perpendicular to the c-axis in Fig. 7(a). The line contrasts are GP-zones formed by two close-packed planes with an ordered arrangement of Gd and/or Zn atoms, as will be shown later. On the other hand, the β' precipitates are observed as blurred bright and dark contrasts in Fig. 7(a). The HRTEM image of Fig. 7(b) shows that the GP-zones precipitate coherently in the Mg-matrix, and bright and dark dots in the GP-zones show an ordered arrangement with intervals of 2d_{002} and 3d_{100} spacings of a hexagonal lattice of the Mg-matrix.

**Figures 8(a) and (b)** show HAADF-STEM images of the GP-zones, taken with the incident beams parallel to [110]m and [001]m directions of the Mg-matrix, respectively. In Fig. 8(a), dumbbells of bright dots with an interval of about 0.5 nm are periodically arranged with an interval of about 0.5 nm along the GP-zones. It is reasonably considered that these intervals correspond to those of 2d_{002}=0.52 nm and 3d_{100}=0.48 nm, respectively, as shown in Fig. 7(b), and that the bright dots represent Gd and/or Zn atoms projected along the [110]m direction. On the other hand, the image of Fig. 8(b) shows a hexagonal arrangement of weak bright dots, with an interval of about 0.6 nm. The weak contrast in Fig. 8(b) is due to only two layers of Gd and/or Zn atoms of the GP-zone embedded in about 100 atomic layers of the Mg-matrix. That is, the result demonstrates that HAADF-STEM makes it possible to observe an image contrast of two layers of Gd and/or Zn atoms embedded in the Mg-matrix with a few tens of nm in thickness. Although many GP-zones embedded in the Mg-matrix produce the 1/3 1/3 0-typed extra spots in Fig. 6(a), it is impossible to form the image contrast of the GP-zone in the HRTEM observation.

From the images of Fig. 7(b), 8(a) and 8(b), we can directly derive a structural model of the GP-zone, as shown in **Figure 9**. In the model, Gd and/or Zn atoms occupy at ordered positions in two close-packed planes sandwiching a close-packed plane of Mg-atoms. The bright dots in Figs. 8(a) and 8(b) represent Gd and/or Zn atoms projected along the incident beam parallel to the [110]m and [001]m directions, respectively. The atomic arrangement of the GP-zone is similar to that of plate-like precipitates found in Mg-2.4wt%RE-0.4wt%Zn-0.6wt%Zr alloys [15], and also can be seen in the crystal structure of a precipitate phase in rapidly solidified Mg-2at%Ce-1at%Zn and Mg-2at%Ce alloys [16].

**Conclusion**

We have reviewed recent results for microstructures of coherent precipitates in Mg-based alloys containing rare earth elements, studied by the combination of HRTEM and HAADF-STEM. Direct observations of individual rare earth atoms projected along the incident beam by HAADF-STEM enable us to determine directly arrangements of rare earth atoms in a hexagonal Mg-lattice. On the other hand, HRTEM images show crystallographic relationships between lattices of precipitates and the Mg-matrix. Therefore, it can be concluded that the combination of HRTEM and HAADF-STEM is the most powerful tool for characterization of fine precipitates being coherent with the matrix crystals.

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**References**

Quantitative Electron Microscopy Using Digital Data Processing

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Introduction

Current hot topics of high-resolution electron microscopy are high-resolution STEM-HAADF imaging and spherical aberration correction of an objective lens using a multi-poles corrector. There are two types of corrector, one is for a probe forming objective lens in a STEM mode, and the other is for an imaging objective lens in a CETM mode. When a spherical aberration is corrected, we can expect in principle an improvement of resolution. However, it does not simply mean that getting an atomic resolution image becomes easier using a Cs-corrected microscope than using a conventional microscope. Especially in a CTEM mode a sample for high-resolution microscopy is well approximated as a phase object. Thus, when a spherical aberration is corrected in CTEM, at a just defocus our sample only gives a weak scattering contrast (amplitude contrast). Furthermore, to realize an improvement of resolution we will be faced with unprecedented demands for stability of microscope and skills of operating a microscope and preparing a good sample.

On the other hand, digital equipments for electron microscopy, such as a CCD camera, come into wide use, and performance of a personal computer becomes more powerful than that of a main computer a decade ago. Thus, quantitative electron microscopy becomes a reality, where digital data obtained by using an electron microscope is analyzed quantitatively. Quantitative electron microscopy makes it possible to deduce information from an observed data, which is hard to be detected before by using human eyes. This report will introduce quantitative electron microscopy by making use of the data taken with JEOL JEM-2100F using some of the plug-ins developed at HREM Research for DigitalMicrograph (Gatan).

Resolution Improvement of STEM-HAADF Image

A STEM-HAADF image can be approxi-
Here, we will show an example of deconvolution applied to a STEM-HAADF image of a decagonal quasi-crystal Al_{64}Cu_{22}Co_{14} (Fig. 1(a)) taken with JEOL JEM-2100F equipped with CEOS Cs-corrector for STEM [8]. If you are interested in details on a sample and its analysis, please consult an original article [9] by the authors who kindly provide this image for our analysis. In the case of Cs-corrected STEM we can extend a convergence angle for probe forming lens, and thus a resultant probe becomes so small that we have to take care of the size of a physical source demagnetized by a condenser system. Moreover, a large convergence angle means a depth of focus becomes small, and thus we have to consider a focus spread due to chromatic aberration. These two points have been ignored for STEM-HAADF imaging with a conventional STEM without a Cs-corrector. We improved recently a probe function of DeConvHAADF to include these two effects.

Figure 1 (b) shows the result of a MEM deconvolution using a probe obtained for Cs = 0 mm at a just focus with 24-mrad convergence angle. The demagnified source size is approximated by a Gaussian with FWHM of 2 pixels, while a focus spread by a Gaussian with FWHM of 5 nm. Contrast is adjusted in a rectangle box to enhance weak peaks. Salt-and-pepper noise in the experimental image is reduced, and blurred contrast becomes sharp. On the other hand, some peaks appear at the places where the experimental image does not show clear evidence of their existence. However, we may note that the result of deconvolution including the latter peaks satisfies the experimental image, and seems to correspond to an expected average structure of decagonal quasi-crystal shown in Fig. 2 [9].

**Single Atom Detection by Noise Suppression**

Figure 3 (a) shows a STEM-HAADF image of PtRu catalyst particles on carbon support taken with JEM-2100F equipped with CEOS Cs-corrector for STEM [9]. As you can see from this figure aperiodic material such as carbon film gives pixel-wise random noise in a STEM-HAADF image. We have demonstrated that deconvolution is effective to improve resolution of a STEM-HAADF image, namely to correct a spherical aberration of a probe forming lens. It is also effective to reduce the pixel-wise random noise as we will describe in this section. This is because an observed image is given by a convolution integral between an object function and a probe function, and thus each pixel of the observed image should not be absolutely random.

When we continuously observe PtRu catalyst particles, a bright spot occasionally migrates from a border of a PtRu particle. The bright spot is believed to be a single atom of Pt or Ru. Figure 4 (a) is an intensity profile along the line connecting two bright spots indicated by red arrowheads in Fig. 3 (a). We can recognize the presence of these bright spots from a STEM image, when weak intensity is enhanced as in Fig. 3 (a). However, it is difficult to determine a strength and size of the
Occasionally, we want to quantitatively measure intensity of each column of a lattice image for such a case to identify constituent atoms of the columns. However, measuring intensities at many column positions manually to get a statistical estimation is a laborious work. On the other hand a number of techniques to measure lattice distortion from a single lattice image with accuracy of an order of 1% (absolute distortion of an order of pm) were proposed, and some of them were made available commercially. GPA (Geometrical Phase Analysis) [10] is one of such plug-in.

Measurement of Lattice Distortion and Column Intensity

Occasionally, we want to quantitatively measure intensity of each column of a lattice image for such a case to identify constituent atoms of the columns. However, measuring intensities at many column positions manually to get a statistical estimation is a laborious work. On the other hand a number of techniques to measure lattice distortion from a single lattice image with accuracy of an order of 1% (absolute distortion of an order of pm) were proposed, and some of them were made available commercially. GPA (Geometrical Phase Analysis) [10] is one of such plug-in.
which will be briefly introduced in Other Plug-ins section. In this section we will introduce another strain measurement plug-in called PPA (Peak Pair Analysis) [11] in reference to a STEM-HAADF image of GaAs. PPA estimates lattice strain from a change of distance between column pairs after automatically determining column positions. Since PPA determines column positions, it is easy to get intensity statistics of different columns by automatically measuring intensity at each column position.

Figure 5 (a) shows a STEM-HAADF image of GaAs [100] taken with JEM-2100F equipped with CEOS Cs-corrector for STEM. If we look carefully the image with a help of red reference lines, we can detect slowly varying image distortion. A STEM-HAADF image often shows this kind of distortion owing to such as specimen charge-up from electron irradiation, specimen change during observation and so on, even when probe scanning is stable. This kind of image distortion can be measured as a lattice deformation. Then, we can rectify image distortion using information on lattice deformation, when actual specimen deformation is negligible. Figure 5 (b) shows pseudo-color variations of x- and y-components of lattice vectors in two directions as a function of image position. Using this information we can rectify a deconvoluted image as shown in Fig. 5 (c). In this image all columns align along straight lines, and it is clear that slowly varying image distortion is corrected.

Since relative relations of all column positions are known, intensity of each column position within a specified region will be automatically measured, when we specify only one column position for Ga and As. Figure 6 (a) to (c) show histograms of peak intensities at Ga, As and both column positions, respectively. Average intensity at Ga is \(3.42 \times 10^6\) \((\sigma = 1.9 \times 10^5)\), while at As is \(3.84 \times 10^6\) \((\sigma = 2.0 \times 10^5)\). Thus, we can significantly discriminate intensities at Ga and As, and determine a polarity of GaAs from a STEM-HAADF image. Although we have to examine a size of background of this image, which is a recent hot topic of STEM-HAADF imaging [12], the relative intensity between Ga and As is 1.12, which is close to a square of atomic number ratio (33/31).

Verification of Cs-correction Using Software

If spherical aberration is present, electrons
scattered into high angle appear on the image plane displaced from an image corresponding to a transmitted wave. This is the reason why sets of lattice fringes appear outside of a particle, when we take an image of small particles. Likewise, lattice fringes extend into vacuum beyond a surface, or into other domain across an interface. One of the advantages of a Cs-corrected CTEM is such that this kind of image delocalization disappears, and a structure at a surface/interface becomes clear. Another advantage is such that a phase contrast from a specimen support, like a carbon film, which is a phase object, is suppressed, and observation of fine particles becomes easier. These advantages can be derived from correcting spherical aberration with software using a series of CTEM images. Moreover, software Cs-correction has further benefits over hardware Cs-correction as shown below.

Here, we will demonstrate that delocalization of lattice fringes on a CTEM image of Au particles disappear, and thus verify that software Cs-correction is in fact possible. We reconstruct here a wave front using FSR (Focal Series Reconstruction) function of FTSR (Focal and Tilt Series Reconstruction) plug-in. FTSR uses a specially designed Wiener filter to estimate a wave front assuming the linear imaging that is valid when a transmitted wave is stronger than diffracted waves. Since the Wiener filter takes into account wave aberration, we can get a Cs-corrected wave front at a specimen exit surface.

Figure 7 (a) reproduces a CTEM image of nano-meter scale Au particles on carbon support taken with JEM-2100F (Cs = 0.5 mm). This image is selected from a through-focus series of 20 images (a defocus step is about 9 nm) to be used for Cs-correction, and a defocus value is about -46 nm (under focus). An enlarged image (Fig. 7 (b)) of one spherical particle (about 6.5 nm) located at the center right clearly demonstrates sets of lattice fringes that appear outside of the particle. An expected displacement of a diffracted image for (311) reflection is 3.3 nm at this defocus. Figure 7 (c) and (d) are respectively an amplitude and phase distributions of the wave function at the specimen exit surface obtained from the through-focus series of 20 images. Spherical aberration was corrected assuming Cs = 0.5 nm. In addition, an estimated two-fold astigmatism of 5.9 nm was also corrected. Displaced lattice fringes observed in original images disappeared, and thus we can conclude that spherical aberration has been corrected successfully. The amplitude image corresponds to a just-focus image taken with a Cs-corrected CTEM. Here, phase contrast from carbon support is suppressed and thus observation of fine particles becomes easy as a hardware Cs-corrected image.

The phase image shown in Fig. 7 (d) seems to be polluted when compared with the amplitude image. However, this is because carbon support film that is a phase object is faithfully observed here. The phase distribution of the wave function at the specimen exit surface obtained by using software is an aberration free image up to an information limit (diffraction limit), even though very low frequencies cannot be recovered. FTSR includes TSR (Tilt Series Reconstruction) function that uses the images obtained by tilting the beam at six directions. It is possible using TSR to reconstruct a wave front with a super resolution, which exceeds the information limit of an axial illumination.

When observing a phase object using a Cs-corrected CTEM the spherical aberration is not completely corrected, but adjusted from a few microns to tens of microns, and then a defocus is tuned to a Scherzer focus corresponding to the adjusted Cs. This imaging condition in principle corresponds to a regular imaging condition proposed by Scherzer [13], although a spherical aberration is far smaller than that of a regular microscope. This means that an image taken at the Scherzer focus using a Cs-corrected CTEM is not an aberration free image. In order to observe a phase object using a Cs-corrected CTEM under an aberration free condition, wave front reconstruction using a series of through-focus images may be performed in the same way as applied to a regular CTEM. Here, attenuation of a phase contrast transfer function is also recovered at all frequencies except very low scattering angles, and thus an image with higher contrast than an unprocessed image will be obtained.

**Observation of Oxygen with Software Cs-correction**

It is widely accepted that a STEM-HAADF image can be interpreted easier than a CTEM image, since the contrast of a STEM-HAADF image does not reverse with a sample thickness nor defocus change, while a CTEM image does. Moreover discrimination of element is easy using a STEM-HAADF image, since a contrast is proportional to a square of atomic number. However, STEM-HAADF is not suitable to detect a light atom. It may be noted that if we correct aberration using software and estimate wave function at the specimen exit surface, the wave function does not depend on a defocus as a CTEM image. Moreover, if a specimen is thin enough, a phase distribution approximately reflects a projected potential of a specimen, and thus it becomes possible to detect a light atom and a...
specimen structure can be estimated more easily.

In this section we will try to detect oxygen in SrTiO$_3$. Figure 7 (a) shows an image of SrTiO$_3$ [001] taken with JEM-2100F (Cs = 0.5 mm) at around the Scherzer focus. A through-focus series of 20 images (a defocus step is about 9 nm) is acquired from this sample. Figure 7 (b) and (c) are respectively an amplitude and phase distributions of the wave function at the specimen exit surface obtained from the 20 through-focus images. They correspond to an area in the box indicated in Fig. 7 (a) close to the specimen edge. A spherical aberration of 0.5 mm is corrected in the same way as applied to the case of Au particles before. In addition, an estimated two-fold astigmatism of 4.9 nm was also corrected. The phase image close to the specimen edge shows a pattern corresponding to a structure model shown in the figure. Here, Sr and Ti-O columns show almost the same contrast. A weak contrast (red circle) at the center of a square made of Sr and Ti-O corresponds to oxygen. A dark contrast (blue circle) at the center of a square made of Sr and Ti-O corresponds to oxygen. Weak contrast at the center of the square made of Sr and Ti-O shows almost the same contrast. Since the first equal thickness fringe of this sample appears at a thickness of about 5 nm, a sample thickness should be less than 5 nm to obtain a phase image that simply reflects the model structure.

**Brief Introduction of Other Plug-ins**

Here, we will briefly introduce other plug-ins for quantitative electron microscopy developed at HREM Research for DigitalMicrograph.

♦ DeConvEELS improves an energy resolution of an EELS spectrum using the same principles used in DeConvHAADF [7, 14].

♦ IWFR/Iterative Wave Function Reconstruction corrects spherical aberration for CTEM using a set of images. Contrary to FTSR this plug-in estimates a wave function at a specimen exit surface using an iterative algorithm. Normally, IWFR requires a fewer number of images to estimate the wave function than FTSR [3].

♦ GPA/Geometrical Phase Analysis estimates lattice distortion from a single lattice image. Contrary to PPA this plug-in determines lattice distortion from phase distributions of the images separately calculated by inverse Fourier transform of different diffraction spots in a Fourier transform of the lattice image [10].

♦ QPh/Quantitative Phase Technology estimates a phase distribution from two or three images based on the so-called transport intensity equation [15]. An electromagnetic field over a large area can be measured without an electron bi-prism and a vacuum reference area required by electron holography. On the other hand a spherical aberration can be corrected by phase information estimated from high-resolution images. Application of this technique to phase contrast microscopy of biological materials is anticipated in future [16, 17].

♦ HREM-Filters enhances periodic structure by reducing a contribution of aperiodic structure from the image (specimen support, quantum noise, etc). This plug-in is especially useful for the image of non-ideal periodic structure, where there are crystals with different orientations, a periodicity changes in direction, an image has distortion, and so on.). The periodicity is effectively enhanced by applying a Fourier filter, such as a Wiener filter, to each small area where a periodicity is uniform [18].

**References**


Case Study on Failure Analysis by Electron Beam Absorbed Current Method

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Introduction

With recent shrinking of feature size and increasing number of metal layers in integrated circuits, determination of the physical root cause by failure analysis is becoming extremely difficult. Especially, due to the multi-layered structures, the case of the failure factor existing in dielectric layer such as Via that connect two metal layers has been increased. In this case, localization of failure site by the layer analysis (Top-Down surface observation for each layer) seldom reaches to the physical root cause, thus cross-sectional observation is required. For cross-sectional observation, improvement of accuracy for precise failure site localization, where a cross-sectional imaging and analysis should be performed, leads to the improvement of determination for physical root cause.

As a method for localizing open/short site in LSI-interconnects, utilizing electron beam ability for focusing, transmission and absorption, the advantage of Resistive Contrast Imaging (RCI) has been reported. In Japan, this method is called "Electron Beam Absorbed Current method." Thus, in this paper, we describe this method as the Electron Beam Absorbed Current method [1-8].

In this paper, using a JEOL Beam Tracer, authors report the results of application of the Electron Beam Absorbed Current method to localize LSI failure sites and some knowledge of usage which was acquired through our study.

Flowcharts for Localizing Failure Sites

In localizing the LSI failure sites, suitable methods are applied depending on failure modes. In general, for DC failure, Optical Beam Induced Resistance Change (OBIRCH) and an emission microscope, for SCAN failure, a software diagnosis tool, for function failure other than SCAN failure, an emission microscope and for memory failure, a fail-bitmap technique are used. In recent years, Dynamic Laser Stimulation (DLS) analysis has started to be used for localizing AC failure [9], [10]. These techniques and tools enable us to localize the failure site from the entire chip level down to the functional block and cell level. A rough guideline for the area of localization using these methods is about a 100 µm square. However, to perform a cross-sectional observation, the area of localization should be achieved at least down to a 100 nm square. For example, in case of LSI interconnects failure, it is necessary to localize accurate failure sites along interconnect with 100 nm width, or specify just one Via that connects interconnects figured in different layers. In case of cell failure, it is necessary to specify one defective transistor within multiple transistor.

Figure 1 shows the flowcharts for localizing failure sites down to 100 nm square range. For interconnects failure, the Electron Beam Absorbed Current method is used, and for cell failure, Nano-probing analysis is applied.

Analysis Examples Using Electron Beam Absorbed Current Method

Some examples using the Electron Beam Absorbed Current method in Fig.1, are demonstrated to localize AC contacts and short-failure in LSI-interconnects.

Short-failure in LSI interconnects

Figure 2 shows an analysis example of functional failure in a half-pitch(hp) 130 nm System on a Chip (SoC) product. The analysis result using an emission microscope indicated two anomalous emissions on the chip. Then, the interconnect that connects with each cell at an anomalous emission site was referred with layout diagram. Then it was found that the total length of this interconnect was 3 mm and also, the target analysis area was spread to a wide area of 1.25 mm × 0.65 mm. In this analysis, the Electron Beam Absorbed Current method was used to localize the area down to a 100 µm square, so that physical analysis can be performed. As a result, an extra interconnect, which is different from defective interconnect was detected on an absorbed current image. This result suggested that a short-site exists on the defective interconnect. The absorbed current image and the short candidate site on layout data are shown on Fig. 3.

The layer analysis was performed till the top surface of Al interconnect for the short candidate site, but no abnormal phenomenon was observed. However, the absorbed current image suggested a high possibility of the existence of a failure in this site. Thus, we polished the AI interconnect but left barrier metal and observed the layer again. As a result, a particle at the bottom of barrier metal on M3 layer was identified as a cause of the shortage. The results of layer analysis were shown on Fig. 4. Generally, layer analysis was not performed in such detailed observation. But in this case, a failure site was successfully localized to an area of about 5 µm × 1 µm by an absorbed current image. Thus, we concentrated on analyzing this area, and then the physical root cause of the failure was determined.

High resistance failure in Via

Analysis example of AC failure in an hp 90 nm SoC product is described here. This failure is a temperature-dependent SCAN failure. We localized a failure site using the flowchart...
Localizing failure sites

Range of localization
- Block level
- Cell level
- Interconnect, Via level
- Failure Tr. level

Present status
Analysis area 100um

Physical analysis
Layer-by-layer analysis
Cross-sectional observation

Localization
- Emission microscope
- OBIRCH
- Software diagnosis tool
- Fail Bit Map

Electron beam absorbed current method
Cell failure
Nano-probe
Physical analysis

Absorbed current image
Localizing short-interconnect
Estimating short-site from layout data

Fig.1 Flowcharts for localizing failures sites.

Fig.2 Short candidate interconnect.

Fig.3 Absorbed current image and short candidate.
Since this failure has a temperature dependence, Dynamic Laser Stimulation (DLS) was applied to a candidate of defective interconnect and node, both of which were extracted from a software diagnosis tool. (Although DLS is generally referred to Soft Defect Localization (SDL), we call DLS in this paper.) DLS result and a superimposed image of a defective node with DLS mapping are shown in Figure 6. This result indicated that the DLS sensitive area exists on the node extracted from the software diagnosis tool, so the failure site was highly assumed to be in this area.

On a circuit simulator, we increased the resistance at failure candidate site with several times, and simulations were carried out. Then the reproducibility of the failure phenomenon had been confirmed when a resistance increased to several million \( \Omega \). After this confirmation, the resistance of this interconnect was measured with a Nano-probing technique. From this Nano-probing measurement, it was confirmed that the resistance at room temperature was about 12 M\( \Omega \) and that at high temperature was about 300 \( \Omega \). These resistances corresponded to the results of simulations.

Furthermore, from the absorbed current image of this interconnect, the contrast of defective interconnect was changed in the site shown in Figure 7. This result also corresponded to the DLS analysis. As a result of comparing with layout diagram, it was revealed that Via exists in this site. Then, a cross-sectional observation of this Via was performed, indicating that a void exists in the Via. This void was considered to be caused during filling process of the hole.

In this example, all results from various analysis tools were in good agreement, so it was said that the accuracy of the localization was sufficiently high. Also, it was found that the Electron Beam Absorbed Current method could give useful information for failure localization.

Low resistance failure in Via

Figure 8 shows an analysis example of function failure on an hp 90 nm SoC product. In this example, an emission microscope analysis detected anomalous emission and this result suggested an open failure in the interconnect between the cell and the emission site. As a result, cross-sectional TEM observation indicated open Via in this interconnect. However, in the process of the localizing, an
suggests that a resistance at this point should be relatively low.

To detect such a low-resistance failure site using the Electron Beam Absorbed Current method, we found that a lower primary electron beam current was required. Figure 9 shows the variations of absorbed current images when the probe current was set to 36 pA and 530 pA while the accelerating voltage was varied from 10 kV, 13 kV, to 15 kV. In the case of a probe current of 530 pA, regardless of the accelerating voltage (10 kV, 13 kV, 15 kV), whole interconnect appeared on the images. On the other hand, in case of a probe current of 36 pA, the boundary of the contrast at the failure site was recognized at an accelerating voltage of 10 kV. However, when the accelerating voltage was increased to 13 kV and 15 kV, it became difficult to recognize the boundary at the failure site. In Fig.8, although the interconnects are located on the same fourth metal layer (M4), the absorbed current image showed a featureless dark contrast. Thus, the open failure is expected to exist on the Via between the interconnects on the fifth metal layer (M5).

This result indicates that, in order to detect a low-resistance open failure, it is necessary to reduce the probe current and the accelerating voltage. However, by suppressing the probe current and the accelerating voltage, the image contrast becomes poor, so to increase the detection rate of low-resistance open failure and to get far contrast of the image are a trade-off relation. In general, in order to improve the image contrast, the probe current and the accelerating voltage are set relatively higher. However, when the prioritizing the
prevention of improper contrast at the low-resistance open failure, it is necessary to start observation from lower probe current and lower accelerating voltage to higher. On this sample, observation by two probes method was also performed. Figure 10 shows absorbed current images obtained with one probe and two probes, respectively. In the case of one probe, whole interconnects are appeared on the image at a probe current of 36 pA and 500 pA. No boundary of the contrast is recognized at the open failure site. On the other hand, in case of two probes, a clear boundary of the contrast appears at the open failure site at both 36 pA and 500 pA. This result demonstrates that when two probes method is available, the low-resistance open failure can be detected regardless of high and low probe current.

Discussion on an undetectable low-resistance open failure

In the present study, when one probe was used for detecting the absorbed current, some results showed that whole interconnects were seen as the absorbed current image even if these interconnects contained a low-resistance open failure. This will lead to the misunderstanding of failure localization process in LSI failure analysis. Thus, in order to prevent misunderstanding of failure sites localization process, we made a physical model for this phenomenon and obtained the optimum observation conditions.

Figure 11 shows the equivalent circuits for device, where an Electron Beam Absorbed Current method was applied. In addition, Fig. 11 also shows the total equivalent circuit including an electron microscope, which was considered to be the corresponding power supply. When the probe current is 36 pA, the boundary of the contrast along the interconnect appeared and disappeared depending on the value of accelerating voltage. To keep constant probe current of 36 pA, when the voltage of power supply (accelerating voltage) changes, the output impedance Z of the power supply needs to be changed. When the probe current is 36 pA and an accelerating voltage is 10 kV, that is the condition of Z<<R, low-resistance open failure site can be observed. Here, R denotes the resistance at failure site. And when the probe current is 36 pA and an accelerating voltage is set to 13 kV or more, that is the condition of Z>>R, low-resistance open failure site cannot be observed. This model is considered to hold even for the case where the probe current is changed at a
constant accelerating voltage.

This model equation for impedance Z of the power supply is described as below. 

\[ Z = \text{(sample depending constant)} \times \text{Vacc} \times I_p \]  

Further examination and experiment will be expected in the future for this model equation.

In observation by two probes, one probe is connected to ground potential. Thus, no matter how high the impedance Z is, an open-failure site is recognized in the absorbed current image.

**For Z >> R**

Interconnect with improper detection

Constant-current power supply

Absorbed current amplifier

Interconnect subjected to detection

R: Resistance of open-failure site

**Fig.11** Equivalent circuits for device, including an electron microscope considered as the corresponding power supply.

resistance open failure site, it is necessary to set the accelerating voltage and the probe current to lower values.

**Conclusion**

The Electron Beam Absorbed Current method was applied to the localization of failure sites of actual devices, and the following knowledge was acquired.

1) By combining a software diagnosis tool, an emission microscope and DLS with the absorbed current image, AC failure sites can be localized.

The Electron Beam Absorbed Current method can give useful information for improvement of the accuracy to localize failure sites.

2) In observation by one probe, the absorbed current image may cause improper detection of failure sites under some observation conditions.

Based on the knowledge acquired from this study, we will clarify the model that explains the conditions for improper detection in observation by one probe. And furthermore, we will examine detectable resistance in LSI interconnects.

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**References**


Recent Advances in Transmission Electron Microtomography for Materials Research

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This featured article summarizes recent advances in an emerging three-dimensional (3D) imaging technique, transmission electron microtomography (TEMT), and its applications to a class of "soft materials", i.e., polymer-related materials such as nanocomposites and block copolymers. With some recent developments made in TEMT, it is now possible to obtain truly quantitative 3D structural data in subnanometer resolution. It is also demonstrated that, with the combination of TEMT and other experimental technique, e.g., the scattering, it becomes possible to study nano-structures that have been difficult to characterize before. The structural information obtained from the 3D imaging provides a good opportunity not only to gain essential insight into the physics of self-assembling processes and the statistical mechanics of long chain molecules but also to establish the "structure-property" relationship in polymeric materials.

Keywords: 3D Imaging, Transmission Electron Microtomography, 3D Digital Image Analysis, Block Copolymers, Microphase-separated Structures,

Introduction

Polymer materials are ubiquitous in our daily life. They often consist of more than one species of polymers and thus become multi-component systems. The most simple and representative examples are polymer blends [1, 2] and block copolymers [3]. Due to repulsive interaction between the constituent polymers, the multi-component polymer materials often involve "phase-separation." Studies to characterize the phase-separated structures inside the materials have been growing intensively over the past three decades. Academic interest in the complex fluids (to which polymeric systems belong) as well as a ceaseless industrial need for developing new materials activated such studies.

In academia, pattern formation and self-assembling processes of polymer blends are one of the most fascinating research themes in non-linear, non-equilibrium phenomena. The block copolymers, consisting of multiple, chemically dissimilar sequences covalently linked together, likewise self-organize (equilibrium) phase-separated nanometer-scale structures (termed as "microphase-separated structures") due to the presence of chemical junctions inside the molecule. When phase-separated, the block copolymers need to place their chemical junctions at the interface between the microdomains and the block chains must uniformly fill the corresponding microdomains in the most entropically favored way. Due to such constraint, the block copolymers normally form highly-periodic nanostructures. In industry, deep understanding of such phase-separated polymer systems is also important to create nanomaterials with superior physical properties. The structure-property relationship in multi-component polymeric materials is of significant importance, basic studies on which eventually render new design of polymer materials satisfying the diverse requirements of industry.

Up to now, morphological studies of the multi-component polymeric materials have been carried out by various microscopic and scattering methods. Optical microscopes, transmission electron microscopes (TEM), scanning electron microscopes (SEM) and atomic force microscopes (AFM) are commercially available and widely used. The biggest advantage of the microscopy is to provide real-space representations of morphologies. However, when it comes to "measurements," especially in a quantitative manner, the microscopy sometimes lacks statistical accuracy due to the small field of view. In contrast, the scattering methods provide much superior statistical accuracy to the microscopy simply because the observation volume is much larger than that of the microscopes. One must remember, however, that the scattering methods require "(hypothesized) models" for data analysis: The scattering methods do not provide intuitive insight into the morphologies as the microscopy does. After all, for the complete characterization of the morphology, one may need to know the morphologies first by the microscope and subsequently to evaluate the structural parameters by the scattering on the basis of the morphology: The two methods are complementary.

Recently, the phase-separated structures, especially the microphase-separated structures, are becoming increasingly complicated with the advance of the precision polymerization. Identification of such complex morphologies becomes more and more problematic. Micrographs taken by TEM are often inconclusive, which makes the interpretation of the accompanying scattering data difficult. The microscopes mentioned above take two-dimensional (2D) (transmitted or surface) images of three-dimensional (3D) objects. The...
more complicated the morphologies are, the less convincing the 2D images usually become. It is quite natural to develop new microscopes that are capable of obtaining 3D images.

Laser scanning confocal microscopy (LSCM) has been developed in the 1980s and widely used first in the biological community for 3D direct observations of cell morphologies. After a slight delay, it has become popular in the materials community. In polymer society, LSCM was first used to observe the bicontinuous morphology of a polymer mixture during the spinodal decomposition [4-6]. X-ray computerized tomography (X-ray CT) is another technique for 3D imaging that has similar spatial resolution: a micrometer-resolution. The biggest advantage of X-ray CT to LSCM is the strong penetrative power of the X-ray so that it can be readily used for opaque materials. Although quite useful, these two microscopes are not appropriate for nanometer-scale structures.

Transmission electron microtomography (TEMT) is an emerging technique for the 3D structural observations for polymer nanotechnology. Although the first paper using TEMT appeared as early as 1988 by Spontak et al. [7] in polymer society, it has not been extensively used until recently when the high-speed and large-scale computing became available to the scientific community. In the new millennium, TEMT is becoming more frequently used around the world not only in polymer science [8, 9] but also other materials science [10-12] and biology [13]. Thus, the contents of the present featured article can be universally applicable to many fields of science.

Recent Development in Transmission Electron Microtomography (TEMT)

In the TEMT experiments, a series of tilted transmitted images (projections) is taken by TEM, which is used to reconstruct tomograms on the basis of computerized tomography (CT). The tomograms are then stacked to generate a 3D reconstructed image (“3D reconstruction”). There is an intrinsic limitation of angular range for the tilting experiment available in TEM, resulting in a "missing wedge" of structural information in the Fourier space (see the following section for details). Due to the missing wedge, resolution along the direction parallel to the optical axis of the microscope (the dimension perpendicular to the plane of the specimen), i.e. the Z-direction, is reduced compared to that in the specimen plane [14]. In addition to this primary effect, a less appreciated but probably critical effect of the missing wedge is that the imaging of objects in the 3D reconstruction, especially anisotropic ones, depends strongly on their angle relative to the tilt axis. This effect will be detailed in the forthcoming section below. Although the cylindrical and lamellar morphologies of the block copolymers could be influenced by the latter effect in the TEMT observations, none of the previous studies considered the effect [7].

Fig.1 Demonstration of the effect of geometrical relationship between the direction of tilt axis and the orientation of cylindrical nanodomains on 3D reconstruction. There are three types of geometrical relationships. Each column shows a model, three cross sections of 3D reconstruction and a "missing wedge" in the Fourier space (shown by the gray volume), from top to the bottom. The cylindrical nanodomains rotate around the tilt axis from -60° to 60° with a 1° increment. Tilt axis is always along the X-direction. The electron beam comes from the top (from the Z-direction). An X-Z cross section is a tomogram where the filtered back projection (FBP) is carried out. In the bottom-most row, diffraction patterns from the infinitely-long cylinders are shown together with the missing wedge. Because the missing wedge is the volume where no projections can be sampled, diffraction spots within this wedge cannot contribute to the resulting 3D reconstruction.

Fig.2 Comparison of the missing volume in the Fourier space between (a) dual-axis tomography and (b) single-axis tomography. Directions of the tilt axes in the dual-axis tomography are along \( q_x \) and \( q_y \) axes. In single-axis tomography, the tilt axis is along the \( q_z \) axis. Hexagonally-packed infinitely-long cylindrical morphology aligned along the Y axis as shown in Fig. 1(b) gives a diffraction pattern only in the \( q_x - q_y \) plane. Some of the diffraction spots are outside the "missing pyramid" and hence the cylinders can be reconstructed in dual-axis tomography [part (a)], while all diffraction spots are inside the "missing wedge" in single-axis tomography [part (b)].
Dual-Axis TEMT

A problem in a single-axis TEMT: The "Missing Wedge" problem

Figure 1 shows a simulation of the single-axis TEMT for cylindrical morphologies. As shown in Fig. 1(a) to 1(c), three different geometries of the cylinders with respect to the tilt axis and orientation were simulated. In these figures, the hexagonally-packed cylinders orient in three different directions while the tilt axis is fixed to the X-direction. The cylinders were tilted around the tilt axis typically from -60° to 60° with an increment of 1°, from which the filtered back projection method [15, 16] was used to obtain tomosgrams. Figures 1(d) to 1(l) display cross sectional images of the 3D reconstruction. In the Y-Z plane, the cross sections (d) and (f) that correspond to the model (a) and (c) were properly reproduced. On the other hand, the cross section (e) from the model (b) was poorly reconstructed; The horizontal stripes should be observed. Figs. 1(g) to 1(i) and Figs. 1(j) to 1(l) show, respectively, the X-Z and X-Y planes. Although the cross sections relevant to the model (a) and (c) were obtained with reasonable accuracy, again, the cross sections corresponding to the model (b) [see Figs. 1(h) and 1(k)] were not correctly reconstructed. In fact, judging only from the cross sectional images obtained from the model (b), i.e., Figs. 1(e), 1(h) and 1(k), one could misidentify the 3D structure with the lamellar morphology whose lamellar normal aligned to the X axis. Thus, if the orientation of the cylindrical nanodomains geometrically satisfies the relation with the tilt axis as shown in Fig. 1(b), it is very likely that the cylinders do not appear in the 3D reconstruction.

This problem can be understood by considering a relationship between a projection in the real space and the Fourier space. The "central slice theorem," upon which CT relies, states that the Fourier transformation of a projection at a given angle is a central section through the object [15]. Namely, each projection will equate to part of an object's Fourier transform. Therefore, in principle, tomographic reconstruction is possible from the superposition of a set of Fourier transformed projections. If some projections are missing due to the limited angular range of TEM, then the Fourier space is undersampled in those directions. The unsampled volume in the Fourier space becomes wedge-shaped and thus is called the "missing wedge." As a consequence of this unsampled volume, the back transform, the tomogram of the object, will be degraded. Figures 1(m) to 1(o) demonstrate the missing wedge in the Fourier space (translucent gray volume) and "diffraction patterns" of the cylindrical nanodomains relevant to the geometries shown in Figs. 1(a) to 1(c), respectively. In the case of Figs. 1(m) and 1(o), part of and all of the diffraction spots are outside the missing wedge, and hence it is feasible to obtain the reasonable 3D reconstructions. In fact, the image quality of the 3D reconstruction of model (c) appears to be the same as those in Fig. 3. Black phase is PI microdomain. Cylindrical microdomains are completely reconstructed not only in the X-Y plane but also in the other two orthogonal cross sections. Scale bar shows 200 nm. (b) Surface-rendered 3D images obtained from dual-axis tomography, where the PS region has been made transparent. Box size of the 3D image is 250 nm × 250 nm × 115 nm.
best among the three geometries [see Fig. 1(l) for example]. On the other hand, all the diffraction spots are inside the missing wedge in Fig. 1(b), resulting in an insufficient 3D reconstruction.

One of the most effective ways to solve this problem is to minimize the volume of the missing wedge. Increasing the tilting angle of the specimen may be one possible way; however, this strategy would not help much especially in the case of the 3D observation of cylindrical morphology as demonstrated in Fig. 1(b). Another strategy is to have another tilt axis in addition to the first one. Figure 2 demonstrates such “dual-axis tomography”: In Fig. 2(a) the unsampled volume of the dual-axis tomography is shown. Compared with the missing wedge shown in Fig. 2(b) (that is the reproduction of Fig. 1(t)), the unsampled volume in the dual-axis tomography, called the “missing pyramid,” becomes considerably smaller than the missing wedge. Some of the diffraction spots of the cylindrical nanodomains are now outside the missing pyramid even in the case of the geometry shown in Fig. 1(b), Penczek et al. [17] pioneered the dual-axis tomography for thick biological sections, followed by Mastronarde [18].

Dual-axis TEMT on a cylindrical microphase-separated structure

Figure 3 shows the results of a 3D reconstruction of a cylinder-forming poly(styrene-block-isoprene) (SI) copolymer. Experimental details can be found elsewhere [14].

Figures 3(a) and 3(b) display, respectively, orthogonal views of the two 3D reconstructed volume data with the tilt axes in different directions, i.e., the X- and Y-directions. The solid and dashed lines in each cross sectional slice represent positions of the other two orthogonal slices. The thickness of the each digitally-sliced cross section in Figs. 3(a) and Figs. 3(b) is equal to the edge length of a voxel, i.e., 1.9 nm. These images were outstandingly clear due to essentially no overlap of the nano-structure. The cross sectional slice will be called a “digital slice” throughout this paper. We note here that one of the biggest advantages of TEMT is that it obtains truly 3D information on intact block copolymer morphology by digital sectioning, instead of physically cutting the materials into slices.

The two 3D reconstructions show exactly the same volume of the specimen except for the direction of the tilt axis. It is clear that the SI block copolymer exhibited PI cylindrical morphology. The cylinders lay parallel to the film surface. The thickness of the film was determined to be ca. 160 nm from the cross sections in the X-Z plane in Fig. 3(a) and Y-Z plane in Fig. 3(b). It was found that there were 6 layers of cylindrical nanodomains in the film as observed from the X-Z plane in Fig. 3(a) and Y-Z plane in Fig. 3(b).

It is quite intriguing that some parts of the 3D reconstruction either in Fig. 3(a) or in Fig. 3(b) were not properly reconstructed: the horizontally-oriented cylinders shown by a circle in the X-Y plane of Fig. 3(a) were vaguely visible, while they were clearly visible in the Y-Z plane of Fig. 3(b). As described earlier, the cylinders in this area fulfilled the geometrical relation as shown in Fig. 1(b), and hence they were not properly reconstructed in Fig. 3(a).

On the other hand, the same cylinders were parallel to the tilt axis (X-axis) in Fig. 3(b), corresponding to the situation shown in Fig. 1(a). Thus, they were successfully reconstructed [Fig. 3(b)].

The interface between the PI and PS nanodomains were found by binarizing the morphologies in the X-Y plane and was modeled according to the marching cubes algorithm (MCA) [19]. Figures 3(c) and 3(d) show surface-rendered 3D images of the SI block copolymer corresponding to those displayed in Figs. 3(a) and 3(b), respectively. The tilt axes are indicated by rods. The volume fraction of the PI microdomains evaluated from Figs. 3(c) and 3(d) were, respectively, 0.16 and 0.15, in contradiction to the known composition of the copolymer, 0.22.

The two 3D reconstructed data were combined in the Fourier space, the detailed protocol of which can be found elsewhere [14]. Orthogonal views of the combined 3D reconstruction are displayed in Fig. 4(a) together with a corresponding surface-rendered 3D image in Fig. 4(b). Because the positions of the orthogonal views in Fig. 4(a) are exactly the same as those in Figs. 3(a) and 3(b), it is now obvious how much the dual-axis tomography can improve the single-axis 3D reconstructions: Not only in the lateral plane (X-Y plane) but also in the cross sectional planes, i.e. the X-Z and Y-Z planes, cylindrical microdomains were visible regardless of their orientations. The volume fraction of the PI domains evaluated from the surface-rendered image was ca. 0.22.

TEMT without “missing wedge”

In the previous section, the dual-axis TEMT was introduced to reduce the missing wedge in TEMT. Although the missing region in the Fourier space can be significantly reduced by the dual-axis TEMT, the most faithful tactics for the CT is to tilt the specimen over ±90°. In this section, we demonstrate a complete rotation of a rod-shaped specimen of a zirconia/polymer nanocomposite made by a
focused ion beam (FIB) method that was attached at the tip of a specially modified specimen holder without any supporting film. A complete set of tomograms has been generated from 181 projections that were taken over the angular range of ±90° on a nm scale [20].

**Figure 5(a)** shows an electron micrograph of the rod-shaped specimen. The 5 ~ 20 nm zirconia grains were observed as black domains in the polymer matrix in the enlarged electron micrograph [Fig. 5(b)]. No sign of damage occurring in the FIB fabrication process, such as melting by the gallium ion beam or the redeposition of contaminations, was observed on the surface of the rod-shaped specimen. Note that the applicability of the FIB to polymer materials has also been confirmed on an SI block copolymer [21].

An orthogonal view of the reconstructed 3D image of the zirconia/polymer nanocomposite is shown in **Fig. 6**. The gray region and white small objects are, respectively, the thermoset polymer matrix and zirconia domains. The FBP calculation has been carried out in the X-Z plane, in which the edge of the rod-shape specimen and the zirconia domains were observed. The conventional TEMT in which the angular range is limited to ±60° shows artifacts at the top and bottom of the X-Z plane, and the objects are elongated along the Z-axis [see also Fig. 7] [22]. It is quite impressive that the 3D reconstruction of the nanocomposite is totally free from such artifacts. Moreover, the Y-Z plane, which usually exhibits the worst image quality in the conventional TEMT, appeared as clear as the other two cross sectional slices.

Image artifacts due to the limitation of the angular range prominently appear in the X-Z plane. Because we have the complete data set with ±90° angular tilting, it is worthwhile to demonstrate how the maximum tilt angle affects the image quality in the TEMT experiments. A series of 3D reconstructions with various maximum tilt angles, α, was made. Namely, 3D images were reconstructed from exactly the same TEM tilt series and alignment within the angular range of ±α°. **Figure 7(a)** shows the X-Z cross sections of the same region of the rod-shaped specimen from α = 40° to α = 90° in 5° increments. As α decreased, the image quality, especially the contrast between the zirconia grains and polymer matrix, became worse, and also the edge of the rod-shaped specimen became more like a "pear-shape." Note that the angular range is normally limited to α = 60° ~ 70° in the conventional TEMT observations using planar sections. Although the positions and approximate shapes of the zirconia grains can be observed especially in the case of a small α, they were elongated and some details of the structure were lost.

It is of particular interest in material science as to how accurately one can determine the structural parameters, e.g., volume fraction, φ, of the zirconia grain. φ was measured as a function of deviation from the true value at small α. It is worthwhile to note that we observed a 27% error bar in each measurement was associated with some uncertainty of the threshold in the binarization. φ decreased as α increased and approached a certain asymptotic value for a high α (α > 80°). The known composition of the zirconia grain was 0.055 ±0.005 from the preparation of the sample (dotted line), which is in excellent agreement with the measured asymptotic value, i.e., 0.055. The elongation of the zirconia grains and low signal-to-noise (S/N) ratio of the tomograms may be the cause of deviation from the true value at small α. It is worthwhile to note that we observed a 27% error in φ for the conventional TEMT, i.e., α = 60°, in our zirconia/polymer nanocomposite. Furthermore, we recognized that the angular range of α ~ 70° may be required in order to attain a 10% error in φ in the nanocomposite.

**A New Structural Analysis Based on TEMT**

TEMT [23] is an ideal tool to characterize nano-structures and, as such, it has proven useful for providing high-resolution 3D information on a variety of polymeric structures, e.g., block-copolymer nano-scale microphase-separated structures [7, 24-27, 8], polymer/clay nanocomposite materials [28], carbon black/natural rubber composites [29], etc. Some of these studies provided quantitative structural analysis as well as 3D pictures. For example, topological features, e.g., connectivity of the network, can be also evaluated from 3D images [30].

Although TEMT is used alone to characterize the nano-scale morphologies in most cases, it provides even richer structural information when used together with other techniques. One example is the "TEMT-assisted computer-simulations" in which the simulations are carried out on the basis of 3D images obtained from TEMT. The stress-strain (S-S) behavior of a rubbery material was simulated using the combined technique of TEMT and 3D FEA (Finite Element Analysis) [31]. The virtually obtained S-S behavior was in good agreement with the experimental results obtained by stretching the actual macroscopic specimens. Moreover, the combined technique provides local strain upon stretching inside the materials. Similarly, the local frustration of the block chains, being essential in the block copolymer self-assembly, can be evaluated by the combined method of TEMT and 3D meso-scale computer simu-

![Fig.7](image7.png) A series of X-Z cross sections of the same region in the rod-shaped specimen reconstructed with various maximum tilt angles, α, from 40° to 90° in 5° increments.

![Fig.8](image8.png) Plot of volume fractions of zirconia, φ, experimentally determined from the 3D reconstruction series from α = 40° to α = 90°. Dashed line represents the known composition of the zirconia grain.
lations [32]. We will show two examples in which spectroscopic and reciprocal-space methods are used together with TEMT, respectively, in the two forthcoming sections below.

A nanocomposite consisting of nano-fillers in a rubbery matrix: Element-specific TEMT

Nanocomposites have attracted substantial interest from researchers because they often exhibit unexpected properties synergistically derived from the two or more components [33, 34]. Nanometer size particulate fillers, e.g., carbon black (CB), silica (Si) nano-particles, etc., form hybrids with organic polymers. They show a significant increase in both static and dynamic moduli [35], strength [36], thermal and electrical conductivity [37, 38]. It is therefore important to understand the structure-property relationship in order to achieve better properties in the nanocomposites. TEMT offers detailed 3D characterization of the nanocomposites through various new structural parameters, some of which would never be obtained from other experimental techniques [28, 29, 39].

Among various types of nanocomposites, as a representative example, 3D direct observation and characterization of a nanocomposite with two kinds of particulate fillers in a rubbery matrix [29] will be presented here. One typical example is a composite of CB and Si nano-particles in a rubbery matrix. Hereafter, we call the nanocomposite CB&Si/NRBR (the matrix is a blend of natural rubber (NR) and polybutadiene (BR)). In this composite, the CB increases the strength of the elastomer [40, 41] and thus acts as a reinforcing filler, while the Si nano-particles may add tear strength, abrasion resistance and a reduction in the heat built-up. In order to improve and maximize such functionalities, it is first necessary to independently visualize the two kinds of fillers in the matrix and to determine their 3D spatial distributions.

Until recently, the filled polymers have been observed by TEM and other experimental techniques, e.g., scattering methods [42]. There are, however, several experimental difficulties for an accurate structural analysis: (i) It is often difficult to distinguish the CB from the Si nano-particles under TEM in spite of their relatively large electron-density difference. Even though the fillers are discernible in principle by TEM, because there is an overlap of the fillers in the depth direction of the specimen (Z direction), in reality, it is difficult to distinguish one filler from the other. (ii) TEM provides only a 2D projection of a 3D structural body. For the former problem, electron energy loss spectroscopy (EELS) [43, 10, 44], which enables us to obtain an elemental-mapped image, would be useful. For the latter problem, TEMT [23, 8, 9] is a solution. Thus, the two techniques are combined. "TEMT-EELS" will provide elemental-mapped 3D image of materials. Detailed information about the nanocomposite and experimental protocols, especially about TEMT-EELS, can be found elsewhere [29].

Figures 9(a) and 9(b) show the digital slices of the TEMT and TEMT-EELS volume data at the same position of the CB&Si/NRBR specimen. A corresponding TEM micrograph is shown in Fig. 9(c). From the TEM micrograph [Fig. 9(c)], it is possible to judge the extent of the dispersion of the fillers in the rubbery matrix. However, because the fillers overlapped along the Z-direction and resolution along this direction is lost in the TEM, the identification of each filler was impossible. In contrast, the digital slice of the 3D reconstruction [Fig. 9(a)] had a higher contrast than the TEM and the detailed features, i.e., the spatial arrangements of the fillers, were clearly observable. What is intriguing is that there are two kinds of fillers appearing differently in Fig. 9(a): One appeared solid, while the other was rather transparent in the middle with their

Fig.9 (a) A digital slice of TEMT, (b) A digital slice image of 3D reconstruction from TEMT-EELS, and (c) TEM micrograph in the same field of view of the CB&Si/NRBR system. White circles indicate the same aggregate, i.e., Si aggregate, in the three pictures. Bar shows 100 nm.

Fig.10 (a) 3D reconstruction of CB&Si/NRBR system. Blue and red regions consist of CB and Si nano-particles, respectively. (b) 3D reconstruction of CB&Si/NRBR system after the particle-packing analysis. The blue and red balls represent the CB and Si nano-particles whose diameters are 22 and 17 nm, respectively. The CB and Si regions are translucent in part (b). Bar shows 200 nm.
edges having a strong contrast, somewhat like hollow spheres. Assignment of these two kinds of particles either to the CB or to the silica particle is necessary in order to understand the 3D morphology of the CB&Si/NRBR system.

In the TEMT-EELS experiments, a 3D reconstruction was carried out from the series of energy-filtered Si mapped projections. Thus, the black particles in Fig. 9(b) correspond to the Si nanoparticles. The image quality of the digital slice in the TEMT picture [Fig. 9(a)] is better than that in the TEMT-EELS [Fig. 9(b)] mainly due to the lower signal-to-noise ratio (S/N) of the Si-mapped projections and also due to the larger angular increment in the data acquisition of the TEMT-EELS experiment. Nevertheless, the position of the Si nano-particles was clearly seen.

Comparing Figs. 9(a) and 9(b), it was found that the aggregates of fillers marked by a circle in each part of Fig. 9 were silica aggregates. Close examination of the two digital slices provides the following important result: Among the two kinds of fillers observed in Fig. 9(a), the hollow and solid particles are, respectively, the CB and Si nanoparticles.

On the other hand, as found on the results found in Fig. 9, the arrangement of these two kinds of fillers can be directly visualized in 3D [see Fig. 10(a)]. It was found that the aggregates consisted of only one species of the nano-particles. Namely, the CB and Si aggregates are made only of the CB and Si nano-particles, respectively. The size of each aggregate can be measured by separating the aggregates one from the other using the particle analysis algorithm [29, 45].

Although the 3D image shown in Fig. 10(a) exhibits by far richer structural information itself than the TEM micrograph [see Fig. 9(c)], it only shows the outer shape of each aggregate. An algorithm based on the Monte Carlo method called a “particle-packing” algorithm was proposed to virtually pack as many spherical particles as possible inside the aggregates [29]. Figure 10(b) shows the 3D images after applying the particle-packing analysis to the original TEMT-EELS image shown in part (a). The volume fractions of the CB and Si nanoparticles after the particle-packing analysis turned out to be smaller than the volume fractions evaluated from the 3D reconstructions: The virtual CB and Si nanoparticles did not fully occupy the corresponding regions, and hence the particle-packing algorithm is only semi-quantitative. Considering the fact that the CB and Si nanoparticles are not perfect spheres nor monodispersed, we regarded that the agreement of the volume fraction before and after the particle-packing analysis was reasonably good. Most importantly, the shape of the aggregates was well preserved even after the particle-packing analysis, and thus the analysis provides an intuitive understanding of the distribution of the primary nano-particles.

Such spatial position of each primary particle, i.e., individual CB and Si nano-particles, should be quite useful for correlating the internal morphology with various properties, e.g., the mechanical and electrical properties. For example, knowledge of the spatial arrangement of the nano-particles in the composite can be used to estimate the mechanical properties on the basis of FEA [31, 46], which would be a more accurate model than the conventional one in which the nano-particles have been virtually and manually arranged based on the insufficient 2D TEM images. Moreover, the passivant length of each aggregate, an important measure for understanding the electric conductivity of the nano-composite materials, will be evaluated by examining the connectivity of the primary nano-particles [47]. Such a study is in progress.

Besides the CB&Si/NRBR system, TEMT was also applied to a polymer/clay nanocomposite, an organophilic montmorillonite (MMT) dispersed in poly(ethylene-co-vinylacetate) (EVA). Unlike the nanocomposite described here, the clay minerals are plate-like nano-fillers. It is also well-known that the improvement in such properties strongly depends on their dispersion and orientation of the clay layers inside the polymer matrix [48, 49]. 3D morphology of a polymer/clay nanocomposite was studied by TEMT with particular emphasis on the shape and orientation of each clay layer [45].

A block copolymer thin film: Combination with reciprocal-space method

Background

As described in the first section, there are advantages and disadvantages in microscopy and scattering methods. In this section, we demonstrate a novel structural analysis that combines the real space (TEMT) and the reciprocal space (Neutron reflectivity, NR) methods in order to investigate a block copolymer thin film [50].

When the microphase-separated structures are confined in a thin film whose thickness is on the order of 10 to 100 nanometers, the surface interaction (between the block copolymer and substrate or between the block copolymer and air surface) as well as the confinement significantly affects the microphase-separated structures [51]. The block copolymer thin films have drawn considerable attention in many technological areas such as microelectronics [52-55] and nanomorphous films [56, 57]. Guarini et al. reported that block copolymer thin films can be used as the mask layers for dense nanoscale dot patterning [52]. Applications of block copolymer thin film morphologies to the high surface area substrates for capacitors and biochips, quantum dot arrays for nonvolatile memories, silicon pillar arrays for vertical transistors or field-emission display, and transmission electron microscopy have been reported [53-56].

In order to understand the self-assembling morphologies of the block copolymer thin films, it is particularly important to study the self-assembling processes and the resulting morphologies. NR is one of the most useful methods for investigating microphase-separated structures of block copolymer thin films [58]. It provides a concentration (density) profile of one of the components with the very high precision of 0.5 nm. Some important pieces of structural information about block copolymer thin films, e.g., the location of junctions between dissimilar sequences, chain ends inside the microdomains and the interfacial thickness, have been investigated using NR [59-62].

Although powerful, NR first requires a hypothesized concentration profile for data analysis. The concentration profile assumed along the Z direction, i.e., the direction normal to the substrate, is used to fit the experimental obtained NR profile [63]. This “fitting” protocol of the concentration profile to the NR profile heavily depends on the initial concentration profile [64]. Therefore, until recently, NR has been more or less limited to rather simple morphologies that can be easily hypothesized, e.g., a lamellar morphology parallel to the substrate [59-62]. Some more recent studies seek to take advantage of the cylindrical microdomains in the block copolymer thin film, there are only a few studies dealing with cylinders [65, 66] and, to the best of our knowledge, no studies dealing with other types of microphase-separated structures in the block copolymer thin films due to some difficulties in assuming the appropriate initial concentration profiles for these morphologies. Therefore, it is critical to establish a methodology to estimate the initial concentration profiles. In the section below, we demonstrate that the combination of TEMT and NR would be capable of characterizing block copolymer thin films regardless of the type of morphologies.

Neutron Reflectivity measurements

A poly(deuterated styrene-block-2-vinylpyridine) (dPS-b-P2VP) block copolymer that forms a cylindrical morphology in the bulk state was used [50]. We observed the specular reflectance using white neutrons. The measured NR profile from the dPS-b-P2VP, , is shown by the open circles in Fig. 11 where the reflectivity, R, is plotted versus the magnitude of the scattering vector along the Z-direction, q_z.

A rather featureless NR profile was obtained from the thin film, indicating that the microphase-separated structure inside the thin film was not very ordered.

The microphase-separated structure with hexagonally-packed cylindrical microdomains in the thin film [as illustrated in Fig. 11(b)] may be the first choice to start analyzing the NR profile. The cylinders are assumed to be aligned parallel to the substrate according to the results from previous studies [14, 65, 67]. The hypothetical model is based on the structural parameters determined in the bulk state and from the film thickness separately measured by AFM. The scattering length density profile along the direction perpendicular to the film surface was calculated from the model, , which is shown by the dashed line in Fig. 11(c). Because the b/v is smaller for P2VP than for dPS, the peak-top and peak-bottoms in the b/v correspond to the dPS and P2VP phases, respectively (b and v are the scattering length and the molar volume, respectively). There are five bottoms in Fig. 11(c), each of which corresponds to the layer of the P2VP cylinders. It is obvious that the , did not reproduce the NR profile over the entire range of q_z.

The algorithm proposed by Parratt based on a recursive calculation method [63, 64] was employed to fit the to . The resulting best-fit profile and the corresponding b/v are shown by the solid line in Figs. 11(a) and 11(c), respectively. Although the NR profile after the fitting and are in good agreement, there was a considerable deviation especially for the large q_z. This result again indicates that the
Fig. 12 Volume rendered 3D images of the dPS-b-P2VP thin film from two different viewpoints, in which the dPS microdomain was made transparent. The box size of each 3D image is $720 \times 90 \times 344 \text{ nm}$. Arrows on the right of the 3D image indicate the P2VP layers. The 3D image was cropped along the $Y$-direction for viewing clarity (the total thickness in the $Y$-direction was 200 nm). Bar shows 200 nm.

Fig. 13 (a) Scattering length density profile ($b/v$) of the dPS-b-P2VP. The dashed line is the calculated $b/v$ profile from the 3D image obtained by TEMT. The solid line shown in part (b) is the calculated $b/v$ profile from the best-fit reflectivity profile. (b) Reflectivity profile of the dPS-b-P2VP thin film. Open circles are the measured NR profile. The dashed line and the solid line represent the calculated reflectivity profile from the initial model obtained by TEMT and the best-fit reflectivity profile, respectively. (c) The concentration profiles of the dPS-b-P2VP thin film, $\phi$. The solid and dashed lines correspond to the concentration of dPS and P2VP, respectively. Letters on the peaks of $\phi$ are used to specify the layers of dPS or P2VP where S and V denote dPS and P2VP, respectively. Open circles are the measured concentration profile of dPS by DSIMS.

Fig. 11 (a) NR profile of the dPS-b-P2VP thin film (open circles). The dashed line is the calculated reflectivity profile based on the hypothetical model in which the hexagonally packed cylinders are aligned parallel to the substrate. The corresponding $b/v$ is shown by the dashed line in part (c). The dashed line was used as an “initial guess” in the fitting protocol [63, 64]. The solid line represents the best-fit NR profile after the fitting [the corresponding $b/v$ is the solid line in part (c)]. (b) A cross sectional view of the hypothesized initial model of the dPS-b-P2VP thin film cast on a Si substrate. Dark circles and white domain are the edge-on view of the P2VP cylinder and the dPS matrix, respectively. The Z-direction in normal to the film surface. (c) Scattering length density profile, $b/v$, of the dPS-b-P2VP. The dashed line is the calculated profile from the hypothesized model shown in part (b). The solid line is the calculated $b/v$ profile from the best-fitted reflectivity profile.
microphase-separated morphology was not a simple one as hypothesized. Because the NR profile did not show distinctive peaks, it is intrinsically difficult to have a precise and unique best-fit profile unless we have a realistic model for \( b/v \) as the initial guess. Therefore, we employed TEMT to directly visualize the 3D morphology of the dPS-b-P2VP thin film, which will be used as the initial hypothesized model as shown in the following section.

A new method: Combination of NR and TEMT

A cross-sectional section (specimen) for the TEMT experiment was prepared by the FIB method from exactly the same spun-cast sample used in the NR experiments. The reconstituted 3D images of the dPS-b-P2VP thin film are displayed in Fig. 12 from two different viewpoints, in which only the P2VP phase is shown (the dPS phase is transparent). In Fig. 12, the Z-direction corresponds to the depth direction of the dPS-b-P2VP thin film. The details of the 3D morphology of the dPS-b-P2VP thin film are visible in the figure. Although the majority of the cylindrical microdomains were oriented parallel to the substrate and formed six layers as indicated by arrows in Fig. 12, they did not form hexagonally-packed cylinders as hypothesized in Fig. 11(b). In addition, the cylindrical microdomains aligning normal to the film surface that connected the adjacent layers are also displayed by the white circle in Figure 12. It seemed that the cylindrical microdomains were interconnected through such vertical cylinders.

The scattering length density profile obtained from the TEMT image shown in Fig. 12, \( b/v_{\text{TEMT}} \), is shown by the dashed line in Fig. 13(a). The NR profile based on this \( b/v_{\text{TEMT}} \) was obtained from the TEMT experiments, \( R_{\text{TEMT}} \), and shown in Fig. 13(b). Comparing the previous results in Figs. 11(a) and 11(b), i.e., \( R_{\text{model}} \) and \( b/v_{\text{TEMT}} \), (i) \( R_{\text{TEMT}} \) exhibited a more accurate NR profile than the \( R_{\text{model}} \) did, and (ii) \( b/v_{\text{TEMT}} \) had six peaks (as \( b/v_{\text{model}} \) did), but their heights were distinctively different from those in the \( b/v_{\text{model}} \), especially in the middle of the thin film (100 nm ≤ Z ≤ 250 nm), \( R_{\text{TEMT}} \) well and lost one peak (\( q_z < 0.4 \text{ nm}^{-1} \)), but not in the high \( q_z \) region, indicating that the \( b/v_{\text{TEMT}} \) (and thus TEMT) captures the global feature of the dPS-b-P2VP thin film morphology, but the structural details were lost. In other words, TEMT already provides a statistically-averaged structural information by itself but has inferior spatial resolution compared to NR.

The \( b/v_{\text{TEMT}} \) was subsequently used as the initial guess for the fitting. The resulting scattering density profile, \( b/v_{\text{TEMT-fit}} \), and the corresponding reflectivity profile, \( R_{\text{TEMT-fit}} \), after the fitting [63] are denoted by the solid lines in Figures 13(a) and 13(b), respectively. The \( R_{\text{TEMT-fit}} \) showed perfect agreement with the \( R_{\text{TEMT}} \), much as seen in Figs. 11(a) and 11(b).

The volume fraction of the dPS and P2VP blocks normal to the substrate (\( \phi_{\text{dPS-TEMT-fit}} \) and \( \phi_{\text{P2VP-TEMT-fit}} \)) were calculated from the scattering density profile obtained from the fitting, \( b/v_{\text{TEMT-fit}} \), in Fig. 13, which are shown, respectively, by the solid and dashed lines in Fig. 13(c). Accordingly, the concentration profile of dPS was estimated independently from the TEMT and NR using Dynamic secondary ion mass spectroscopy (DSIMS), \( \phi_{\text{dPS-DSIMS}} \) [see the open circles in Fig. 13(c)]. \( \phi_{\text{dPS-DSIMS}} \) showed excellent agreement with \( \phi_{\text{dPS-TEMT-fit}} \), clearly demonstrating that the new methodology combining TEMT and NR provides not only a high-resolution (through NR), but also an intuitive (through TEMT) way of characterizing the block copolymer morphologies. Detailed morphological discussion using the TEMT and NR data can be found elsewhere [50].

The novel methodology proposed in this section can be extended to the structural studies of the block copolymer thin film with more complicated and disordered morphologies. In addition, the methodology may also be extended to the off-scattering specular data [64, 68-71] as well as specular scattering data, i.e., the reflectivity because the 3D volume data obtainable from TEMT provide not only the depth but also in-plane structural information.

Concluding Remarks

This featured article summarizes recent advances in TEMT and its applications to polymer-related materials. With the dual-axis tomography and ultimately with full-rotation of the rod-shaped specimen (≥90° tilt), it is now possible to obtain quantitative 3D data in sub-nanometer resolution. Although not shown, 3D imaging under stretching of a rubber-composite (Si nanoparticles in a rubbery matrix) has been successfully carried out [72]. It would be interesting to observe structural changes upon external stimuli, e.g., stretching, in 3D at the same volume of the specimen. In fact, although only 2D, "in-situ" observations under special conditions, e.g., under high pressure and high temperature, upon applying force, etc., are coming into fashion in the electron microscopy society. A special TEM holder that has AFM capability for simultaneous force measurement and imaging is now available. It can be easily imagined that all those TEM techniques will eventually go to 3D, which should be extremely beneficial to morphological research.

Image contrast and electron beam damage on soft materials are always problems. Staining with inorganic metals, e.g., OsO4 and RuO4, has often been used for the former problem and cryogenic TEM may be the solution for the latter. Phase-contrast TEM is proven to be quite useful to enhance the image contrast [73], which could be a new solution for the contrast-enhancement. These TEM techniques are used together with CT in the biology field and will also be effective in research.

In some cases, structural elements of the order of sub-micrometer are responsible for materials properties. Moreover, most of the polymer morphologies are hierarchical. However, the maximum thickness of the specimen observable under 200 kV TEMT is normally limited to ca. 300 nm, which is too thin for the sub-micrometer structures. On the other hand, LSCM and X-ray CT do not provide such high resolution (their resolution is slightly less than 1 μm, at most). 3D imaging in sub-micrometer scale is currently the "missing zone." It is therefore necessary to develop new instruments that are capable of filling this resolution gap (the existing TEM with very high voltage of 1 MV or more is an ideal instrument for thick samples but accessibility to such an instrument is not always easy). The scanning electron microscopy combined with a focused ion beam (FIB-SEM) [74, 75], high-resolution X-ray tomography system with focusing optics and scanning transmission electron microscopy (STEM) may be the candidates for this purpose. STEM with better optics, optimized not for the ultra-high resolution but for the thick samples, is eagerly anticipated. The fourth dimension, time, should be added to the 3D microscopy in the future.

From the 3D volume data obtainable by TEMT (and other 3D microscopy), some basic structural parameters, e.g., volume fraction of one of the constituents and interfacial volume per unit volume, can be directly and relatively easily measured. These structural parameters are basic, but they are so far inferred from the 2D images and thus are possibly inaccurate. Characteristic length, being readily measured by use of scattering techniques, is also estimated by taking a Fourier Transform of the 3D images. Crystallographic analysis from the 3D images can be done with at least similar precision to the scattering, sometimes better than the scattering when a single grain can be obtained (Note that multiple grains in laser, X-ray and/or neutron beam smear the scattering pattern and accordingly ruin the spot-like pattern).

Moreover, the 3D digital data contains rich structural information that can be extracted with the aid of "cutting-edge" quantitative image analysis. It is possible to go farther to evaluate a new set of parameters. Interfacial curvatures are such examples. Connectivity of network domains of the morphologies is likewise important [30,76]. We emphasize that those geometrical and topological parameters have never been evaluated by any other (conventional) experimental techniques besides 3D microscopy. Thus, 3D microscopy together with the 3D digital analysis have great potential for analyzing structures, and we hope that the methodology will unveil hidden physics in materials science and open up new research areas in the future.

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ESR Study of the Fundamentals of Radical Polymerizations

Introduction

ESR is the most powerful tool for investigating of radical species in radical polymerizations. When well-resolved spectra can be observed, the spectra provide information not only on the structure, properties, and concentration of radicals but also information on the initiating and propagating (oligomeric and polymeric) radicals in radical polymerizations [1-16]. Direct detection of propagating radicals in radical polymerization by ESR spectroscopy has been very difficult, mainly due to a combination of the labile nature and the extremely low concentration of the propagating radicals.

Nevertheless well-resolved ESR spectra in the radical polymerizations of styrene and its derivatives, diene compounds, methacrylates, and vinyl esters were studied in benzene or derivatives, diene compounds, methacrylates, and vinyl esters were studied in benzene or toluene solution under normal polymerization conditions (Fig. 1) [5-7, 10, 12].

An example of an ESR spectrum of the propagating radicals of methyl methacrylate (MMA), observed during a polymerization reaction, is shown in Figure 2. It is well-resolved and shows the characteristic feature of hyperfine structures. Since values of hyperfine splitting constants were determined very precisely from the spectrum, it was able to be reasonably well simulated as the corresponding propagating radical, also shown in the Figure. Based on these spectra, kinetic analysis, especially for estimation of propagating rate constants \( k_p \) of the monomers, was performed. ESR spectroscopy was successfully applied to quantify radical concentration in the polymerizations. However, the direct detection method did not reveal many points that are very significant in radical polymerization chemistry. For example, the life of propagating chain is not known. In the estimation of \( k_p \), chain length of the observed propagating radicals is considered to be long enough for estimation of \( k_p \). However, there has been no clear experimental information on the actual chain length of the propagating radicals observed by ESR. The chain length was just hypothesized to be "long enough". In order to detect the well-resolved spectra, initiator concentration in some ESR experiments was higher than in usual radical polymerizations. Under such conditions, the chain length of the propagating radicals could be shorter than those formed under normal conditions. The chain length of the resulting polymers in the ESR samples can be estimated by measuring size exclusion chromatography (SEC) after ESR experiments. However, the resulting molecular weights, even if they were high enough, do not guarantee ESR detection of radicals with high molecular weights, because detection of shorter chain radicals is much easier than that of longer chain radicals. Therefore, the effect of the chain length of the propagating radicals in the polymerizations should be examined carefully. Moreover, it is extremely difficult to investigate copolymerization systems by the direct detection method. Copolymerization is a very important technique in radical polymerizations and it contains various kinds of propagating chain ends due to, so-called, penultimate unit effects. These problems have not yet been resolved but the development of controlled radical polymerization techniques, especially atom transfer radical polymerization (ATRP), enables us to solve some of these problems.

ATRP is one of the most widely applied polymerization techniques in the field of controlled/living radical polymerization. ATRP allows the preparation of a wide range of polymeric materials with controlled molecular weights and well-defined architectures [17-26]. The polymers formed in ATRP most frequently contain terminal carbon-halogen bonds. Giese et al. has reported that these bonds can be homolytically cleaved by reaction with organotin compounds [27]. Accordingly, various radicals that model the end groups in an ATRP can be formed from the corresponding precursors prepared by atom transfer radical addition (ATRA) and ATRP and the generated radicals can be studied by ESR spectroscopy. For example, polymeric (meth)acrylates with various chain lengths can be prepared as radical precursors by ATRP. Variation of the chain length of these polymeric radical precursors elucidates the affect of chain length on the ESR spectra of the formed radicals.

The investigations of radical reactions are difficult without using model reactions. Poly(meth)acrylates with various chain lengths can be prepared by ATRP and propagating radicals, with various known chain lengths, can be generated from these model precursors. The ESR spectra of these model radicals at various temperatures are expected to show chain length dependence effects. ESR spectra of propagating radicals of methacrylates observed in situ show a clear temperature dependency due to the dynamics of chain ends [5]. This phenomenon can be applied to study chain length dependent spectroscopic variation using model radicals. This method can also be applied to investigate chain transfer reactions.

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for propagating acrylate radicals.

**Direct ESR Detection of Propagating Radicals**

**Progresses of Techniques on the Detection of ESR Spectra of Radicals during Polymerizations**

Many technical problems associated with direct measurement of ESR signals from propagating radicals have been overcome. Direct detection of propagating radicals in radical polymerization by ESR spectroscopy had been very difficult, mainly due to both the labile nature and the extremely low concentration of the propagating radicals. This problem was partly solved by the development of the TM110 mode cavity by Kamachi with a help of the JEOL research group. About 20 years ago, Kamachi et al. observed the ESR spectra of propagating methacrylate radicals under conditions similar to those in conventional polymerization by means of a specially designed flat cell and cavity called TM110 mode cavity [5]. The TM110 mode cavity has the same shape as a TE011 mode universal cavity turned sideways. The magnetic field of the irradiating microwave is normal to a horizontal plane, including the cavity axis, and the magnetic flux density in the TM110 mode cavity is lower than that with a TE011 mode cavity, if one uses a conventional cylindrical sample tube. Because a larger area is available for the ESR measurements under UV-light irradiation with the TM110 mode cavity, the wider lat cell is useful. ESR spectra were observed at an initiator concentration 1 or 2 orders of magnitude higher than the concentration usual radical polymerization using the TM110 mode cavity.

Two important results bearing on the fundamentals of radical polymerizations were obtained through the development of the TM110 mode cavity. One was the observation of propagating radicals in real radical polymerization systems. The other was clear evidence for the presence of steady state radical concentrations during radical polymerizations. From the beginning of the 1990's, relatively well resolved ESR spectra of propagating radicals have been observed using a commercially available TE011 mode universal cavity and normal sample cell, due to both improvement in ESR spectrometers and careful optimization of the preparation of the sample [5, 10-12]. Difficulties in direct detection of ESR spectra of propagating radicals is also due to a complexity of the radical polymerization reactions. It is well known that a radical polymerization reaction involves several elementary processes. Typical elementary processes are shown in Figure 3. In the figure species which have an unpaired electron (•) are paramagnetic and
ESR observable, which means that various kinds of radical species coexist in the polymerization system. In principle, each species can be observed separately as model radicals with the aid of controlled radical polymerization methods as described in the latter part of this paper. However, direct detection of each of the radical species in Figure 3 one by one is very difficult or almost impossible. Especially, the conditions for detection of the propagating radicals during polymerization reactions and measurement of the ESR spectra should be optimized very carefully.

**Radicals generated from azo-initiators.**

The initiation process is a two steps reaction: the 1st step is decomposition of an initiator to form radicals and the 2nd step is an addition of the radical to a first monomer. A reaction scheme of generation of the radical and its hyperfine splitting constants are shown at the left hand side of this figure (measurement condition: solvent; toluene, temperature: 0 °C, modulation: 100 kHz, 0.05 mT, time constant: 0.03 sec, sweep time: 15 mT/8 min).

When an excess amount of monomer is added to the initiator solution, radical polymerization will proceed upon heating or irradiation in a sample cell. The propagating radicals formed in the solution can be observed by ESR. The ESR spectrum of the radical is shown in Figure 4 along with its simulated spectrum. The primary feature of the spectrum is a relatively large heptet with small equivalent three line splitting due to presence of the nitrogen nuclei (I = 2/2). The values of coupling constants shown in the Figure 4 are reasonable for the structure and presence of the nitrogen nuclei (I = 2/2). The small equivalent three line splitting due to methyl protons. Primary propagating radicals (RM*) will be formed by an addition of the radicals to a first monomer.

When an excess amount of monomer is added to the initiator solution, radical polymerization will proceed upon heating or irradiation in a sample cell. The propagating radicals formed in the solution can be observed by ESR.

**Direct Detection of Propagating Radical during Radical Polymerization by ESR**

Well-resolved ESR spectra of the radicals present in the polymerization of styrene and its derivatives, diene compounds, methacrylates, vinyl esters, and vinyl chloride were studied in benzene or toluene solution under usual polymerization conditions [5-7, 10-16]. Selected examples of ESR spectra of these propagating radicals observed during polymerization reactions are shown in Figure 6-13. They are well-resolved and show the characteristic features of hyperfine structures. Since values of hyperfine splitting constants were determined very precisely from these spectra, all of these spectra were reasonably well simulated as the corresponding propagating radicals, also shown in the Figure.

**t-Butyl Methacrylate (tBMA)**

When a mixture of monomer and a radical initiator was heated or photo-irradiated in an ESR sample cell, propagating radicals were formed and the polymerization proceeded. Well-resolved spectra of the propagating radicals of tert-butyl methacrylate (tBMA) have been detected in such polymerization systems at various temperatures as shown in Figure 6. 16-line spectra were clearly observed. They were different from the ESR spectra previously reported for methacrylates (13-line or 9-line...
butyl group in the α as discussed above.

A 13-line ESR spectrum methyl protons and the two splitting lines should be due to the three α-methylene splitting constants of 1.40 mT for one methyl-

trum is accurately simulated using hyperfine calcs of observed ESR spectrum of propagating radicals. Since long-range hyperfine structures due to the one proton (1:1 doublet), and 2.17 mT for

cals of tert-butyl protons of MMA as discussed above.

The presence of small quartet splitting clearly spectrums) [5, 10, 28], but were rationally assigned to viable propagating radicals. Since long-range hyperfine structures due to the methyl protons of the tert-butyl group in the ester side chain did not appear in the spectra the splitting lines should be due to the three α-methyl protons and the two β-methylene protons. Thus the values of their hyperfine coupling constants were precisely determined. The spectroscopic features of the spectra showed clear temperature dependence which can be interpreted by a hindered rotation model of the two stable conformations [5]. The intensity of the inner 8 lines increased with increasing temperature, indicating that there are two exchangeable conformations whose existence have been shown in the elucidation of ESR spectra of methacrylates [5]. At 150 °C, the intensity of the inner 8 lines increased and the ESR spectrum can be interpreted as a single conformation, indicating that the energy difference between the two conformers is small. The observed ESR spectrum of propagating radicals of βBMA at 150 °C is shown in Figure 7 along with the simulated spectrum. The spectrum is accurately simulated using hyperfine splitting constants of 1.40 mT for one methylene proton (1:1 doublet), 1.16 mT for the other one proton (1:1 doublet), and 2.17 mT for three equivalent methyl protons (1:3:3:1 quartet) as shown in Figure 7.

Methyl Methacrylate (MMA) 13-line and 16-line Spectra

ESR spectra of the propagating radicals present in MMA radical polymerizations are shown in Figure 8. A 13-line ESR spectrum has been observed for the propagating radicals in MMA polymerization using TM110-mode cavity. Figure 8a shows an ESR spectrum of the propagating radicals of MMA in radical polymerization at low resolution. This is the so-called 13-line spectrum that has been observed for MMA polymerization systems.

The resolution of the spectrum can be improved by choosing smaller values of modulation width and the resulting highly resolved ESR spectrum of the MMA propagating radicals is shown in Figure 8b. A small 1:3:3:1 quartet splitting due to methyl protons in methyl ester can be observed in the well resolved spectrum. The presence of small quartet splitting clearly indicates that the structure of the radical is the same as that we have estimated as shown in Figure 8. On the other hand, the interpretation of the spectrum turned out to be more complicated by an overlapping of the spectroscopic lines and lowering the S/N ratio due to the presence of the small quartet splitting.

Therefore deuterated MMA (MMA-d3) was used as a monomer in order to simplify the spectra by selective observation of only the α-methyl and β-methylene protons as in the case of βBMA. In MMA-d3 three methyl protons of the methyl ester are replaced by deuterium and since splitting due to deuterium nuclei is 1/6 smaller than that of hydrogen nuclei it is coalesced in the line width. Therefore, only the splitting due to α-methyl and β-methylene protons were observed in the spectra. The spectrum obtained during the polymerization of MMA-d3 is shown in Figure 8c. It is a 16-line spectrum that can be interpreted just like that of βBMA as discussed above.

Now, we can say that the 13-line and 16-line spectra are essentially the same spectrum. The detection of 16-line spectrum also indicates that the propagating MMA radical has a sufficiently long chain length for kinetics study, especially for estimation of $k_p$ as discussed later.

Styrene

ESR spectra of the propagating styrene radicals were clearly observed in a bulk polymer-
ization at various temperatures under irradiation. A typical example of the ESR signal of a propagating styrene radical in a conventional radical polymerization is shown in Figure 9. Simulation of the spectrum provides a close fit with the observed spectrum of the styrene propagating radical; both low and high resolution spectra are shown. These spectra were observed with different modulation width under almost the same conditions. The concentration of the propagating radicals can be precisely estimated by the low resolution spectrum because it has better S/N ratio. Hyperfine splitting constants can be measured precisely using the high resolution spectrum.

### 1,3-Butadiene

A well-resolved ESR spectrum was observed in the radical polymerizations of the 1,3-butadiene with BPO, although a higher concentration of initiator than usually employed for a radical polymerization (5 mol% for monomer) was necessary to obtain a sufficiently resolved spectra to allow investigation of the behavior of the propagating radical (Fig. 10) [15]. Moreover, the steady state of the radical concentration in the polymerization was confirmed by the time dependency of the intensity of the ESR signal at constant magnetic field during irradiation with light (Fig. 11) [15]. The steady state radical concentration had been an assumption in a kinetics study of radical polymerizations. Now, ESR provides experimental evidence for the steady state [5,10].

### Vinyl Acetate

The ESR spectrum of propagating radicals observed during radical polymerization of vinyl acetate at 5 °C is shown in Figure 12 along with its simulated spectrum. Resolution of the experimental spectrum is much improved from that observed using a TM_{110}-mode cavity. The spectrum shows splitting due to one α-proton and two β-methylene protons. Values of these couplings can be precisely measured from the spectrum, although one by one critical assignment is impossible only from these values. Each line split by α- and β-protons exhibits further splitting due to not only methyl protons but also γ-proton because more than five splitting lines can be observed.

### Vinyl Chloride

Measurements of ESR spectra of propagating vinyl chloride radicals were performed by photo-initiated polymerizations with BPO in benzene solution [29]. The spectrum is reasonably assigned to be a normal vinyl chloride propagating radical with hyperfine coupling constants. As shown in Figure 13, clear equivalent quartet due to nuclear spin of the chlorine nuclei (I = 3/2; 35Cl) was observed. In principle, coupling of isotope of chlorine (37Cl) should be also considered. However, the spectrum was not sufficiently well-resolved to show the difference in the hyperfine splitting constants between the isotopes. The obtained signal was reasonably well simulated using the above hyperfine coupling constants, as shown in Figure 13. The hyperfine coupling constant of 1.85 mT due to α-proton is similar to that of the propagating radical of vinyl acetate, suggesting that the radical reactivity of the propagating radical is similar to that of vinyl acetate. To our knowledge, this is the first example of a detection of an ESR signal of propagating vinyl chloride radicals in solution. Careful choice of the conditions is very important to generate the simple, clear, and well-resolved signal.

### Results and Outlook

Owing to both continuous development of ESR spectrometers and optimization of measurement conditions, various kinds of spectra for propagating radicals, which were previously extremely difficult to observe, were recorded at high resolution. These spectra can provide significant information on the nature of propagating radicals because they are obtained from actual polymerization systems. From the spectra shown in this paper, detailed structural information can be obtained from the values of the hyperfine splitting constants. Experimental evidence also determined that there is a steady state of radical concentration in the polymerizations. In formation on the dynamics of the terminal radicals can be obtained form the spectra obtained at various temperatures as shown in the case of ESR spectra of methacrylate propagating radicals. Activation energies of the rotational motion of the terminal radicals can be estimated from the results allowing the structures, dynamics, and kinetics of the propagating radicals to be discussed based on these ESR spectra.

On the other hand, many problems remain unsolved. Two representative problems, and the experiments undertaken to solve the problems by ESR, with the aid of well defined radical precursors prepared by ATRP (Figs. 14,15) will be discussed in the following sections.

### Combination of ESR and Controlled Radical Polymerization Methods

#### Generation of Model Radicals from Precursors Prepared by Controlled Radical Polymerization Methods

In the following two sections, two further examples of the application of ESR spectroscopy to conventional radical polymerizations based on information obtained from controlled/living radical polymerizations will be demonstrated. First is estimation of effect of chain length on propagating radicals which is elucidated by ESR conducted with the aid of polymers prepared by ATRP. Second, is detection of chain transfer reactions on propagating radicals during the polymerization of tBA.

Indeed ESR is one of the most effective methods for estimating values for kp and it is a
The advantage of ESR is that the value of \( P_n \) in these equations can be determined from the observed ESR spectra of the propagating radicals. Detailed analysis of the spectra provides information, not only on radical concentration, but also on the structure and other physicochemical properties of the radicals. Furthermore, steady state radical concentrations can be confirmed from the spectra. On the other hand, the ESR method makes two important assumptions: one is that we observe the propagating radical with sufficiently long chain length and the other is that we observe real propagating radicals. Therefore ESR was employed to examine and quantify some intermediates in an ATRP which should provide a deeper understanding of the ATRP process, including identification of the structure and concentration of the paramagnetic species involved in the polymerization [30-33]. Although it is very interesting, and important for investigation of ATRP, the structural features of the paramagnetic transition metal compounds will not be discussed in this paper.

### Differentiation of the Chain Length of Propagating Methacrylate Radicals by ESR

The spectrum of a propagating methacrylate radical is completely simulated using hyperfine splitting constants of 1.40 mT for one methylene proton (1:1 doublet), 1.16 mT for the other one proton (1:1 doublet), and 2.17 mT for three equivalent methyl protons (1:3:3:1 quartet) as shown in Figure 3b. A characteristic point of this result is estimation of different hyperfine splitting constants for the two methylene protons. This means that the rate of rotation of the end radical is not fast enough to make the methylene protons equivalent on the time scale of the ESR measurement. Thus, it leads to a 16-line spectrum and also another oligomeric radical which may show a 12-line spectrum (Fig. 16).

If we could observe the ESR spectra of radicals with controlled chain length, chain length dependent phenomena could be precisely examined. In order to clarify the phenomena, model radical precursors were prepared by the ATRP technique. ATRP can provide polymers with controlled molecular weights and low polydispersity, and the resulting polymers have preserved terminal carbon-halogen bonds [14-20]. When the carbon-halogen bonds are cleaved homolytically by reaction with organotin compounds, model radicals of propagating chains with given chain length can be generated (Fig. 15 below) [21].

### Differentiating Between Chain Lengths of Propagating Radicals of tBMA

First, a dimeric model radical precursor was prepared by ATRP technique. ATRP can provide polymers with controlled molecular weights and low polydispersity, and the resulting polymers have preserved terminal carbon-halogen bonds [14-20]. When the carbon-halogen bonds are cleaved homolytically by reaction with organotin compounds, model radicals of propagating chains with given chain length can be generated (Fig. 15 below) [21].
prepared by ATRP and purified. A model dimeric radical was generated from the precusor. Clear and well-resolved ESR spectra of the model radical were observed at various temperatures. The ESR spectrum of the radical observed at 150 °C showed a 12-line spectrum, as shown in Figure 17. The two β-methylene protons are almost equivalent in small radicals at such a high temperature. This finding indicates that rotation of the radical chain end is too fast to detect differences in methylene protons on the time scale of ESR spectroscopy.

In order to estimate the critical chain length which would show splitting resulting in a 16-line spectrum, model radical precursors with degrees of polymerization (Pn) of 30, 50, and 100 were prepared by ATRP. Polymers with calculated molecular weights and low polydispersity were obtained. ESR spectra of radicals generated from these precursors were observed at various temperatures. Although the lifetime of the model radicals are very short at 150 °C, clear and well-resolved spectra were observed. These spectra showed similar temperature dependence to that shown in Figure 6. In the case of Pn = 100, a 16-line spectrum was clearly observed at temperatures lower than 120 °C. The intensity of the inner 8 lines increased with increasing temperature, and seems to coalesce into a single line at 150 °C. Similar ESR spectra were observed in radicals from polymeric precursors with Pn = 50 and 30 where the intensity of the inner 8 lines seems to coalesce more clearly to a single line at 150 °C. The ESR spectra appears to be 12-line spectrum, but the 4 lines coalesced insufficiently, indicating that the rate of the rotation of the end radical is not sufficiently fast for the methylene protons to be detected as equivalent species on the time scale of the ESR experiment. The inner 4 lines of 12-line spectrum begin to separate into two lines at Pn = 30, and the separation becomes larger with increasing Pn owing to the lower rate of rotation. The separation was more clearly observed in the propagating radical, indicating that mobility of the chain end radical is restricted.

Comparison of the ESR spectra of dimeric model radical (Fig. 17), model radicals with Pn = 100, and radicals in polymerization systems (Fig. 7) at 150 °C are shown in one figure, Figure 18. A comparison of the separation of the inner lines indicates that Pn of the propagating radical is higher than 100. Values of hyperfine coupling constants measured from these spectra, were plotted against chain lengths. They seemed to show a nearly linear correlation between hyperfine coupling constants and chain lengths in the range up to Pn = 200. Molecular weight (Mn) of the isolated polymers from polymerization system was determined to be 30,000 (Pn = 210) by SEC. The interpretation of the ESR spectra suggests that they correspond to "long" propagating radicals, and are in agreement with SEC. Before these experimental results ESR spectra and overall SEC results did not correlate. However, more experimental results are needed for a comprehensive correlation of kinetic data with ESR spectra.

We can conclude that observation of a 16-line spectrum in ESR measurements can be ascribed to "polymeric" radicals with more than 100 monomer units. Similar differences in ESR spectra were observed for polyMMA radicals generated in situ (Fig. 8). Although the spectra are more complicated, with a small quartet due to ester methyl protons, the ESR spectrum of polyMMA recorded during a polymerization showed a basic 16-line spectrum and the dimeric model radical with a terminal MMA radical showed a 12-line spectrum. Therefore ESR spectroscopy has provided structural information on the propagating radicals at their chain ends.

Direct information on the chain length of the radicals from ESR measurements had not been

<table>
<thead>
<tr>
<th>Experimental 16-line Spectrum</th>
<th>Simulated 12-line Spectrum</th>
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Fig.16 Experimental spectrum for nonequivalent β-methylene protons (16-line spectrum) and simulated spectrum for equivalent β-methylene protons (12-line spectrum) for propagating radical of rBMA.

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<th>Experimental</th>
<th>Simulated</th>
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Fig.17 Experimental and simulated ESR spectra of dimeric model radical of rBMA at 150 °C (measurement condition; solvent: toluene, temperature: 150 °C, modulation: 100 kHz, 0.1 mT, time constant: 0.03 sec, sweep time: 15 mT/4 min).

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Fig.18 Comparison of ESR spectra of radicals of rBMA with various chain length at 150 °C. ESR spectra of dimeric model radical, model radical with Pn = 100, and propagating radical are shown. Characteristic lines were enlarged on the right-hand side.

<table>
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<tr>
<th>Experimental</th>
<th>Simulated</th>
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Fig.19 The ESR spectra observed in radical polymerization of rBA initiated with rBPO under irradiation at -30 °C, -10 °C, and +60 °C (measurement condition; solvent: toluene, 30 % (v/v), modulation: 100 kHz, 0.1 mT, time constant: 0.03 sec, sweep time: 15 mT/4 min).
Further information on the dynamic behavior of the propagating radicals can be obtained from these ESR spectra. The temperature dependence of these spectra can be simulated by consideration of the dynamics of conformational changes of the radicals. The average exchange time between the two conformers was calculated from the simulation of the spectra. The activation energy for rotation of the terminal \(\text{C}_\alpha - \text{C}_\beta\) bond was estimated to be 21.2 kJ/mol [13].

Clarification of the Mechanism of Chain Transfer Reactions in Radical Polymerizations of Acrylates

ESR Spectra Observed during the Polymerization of tert-Butyl Acrylate and Interpretation of the Spectra

Interpretation of ESR spectra observed in acrylate radical polymerizations have been very difficult [34-40]. The ESR spectra observed during radical polymerization of acrylates are very different from those from methacrylates, even under almost identical conditions (Fig. 19). Accordingly, it is difficult to interpret the spectrum to be that of propagating radicals. Spectroscopic changes were observed in ESR spectra during the solution polymerization of tert-butyl acrylate (tBA) as shown in Figure 19. A 6-line spectrum or doublet of triplets with narrow line width was observed at -30 °C. This spectrum can be reasonably assigned to be a propagating radical with two \(\beta\)-methylene protons (1:2:1 triplet) and one \(\alpha\)-proton (1:1 doublet). However at 60 °C, a totally different 7-line spectrum with broader line width was observed. The latter spectrum was much easier to observe than the former one, but traces of the 6-line spectrum can be seen in the 60 °C spectrum. However, the amount of species giving rise to the spectrum is 1000 times smaller than the species that are the predominant source of the high temperature spectrum. At -10 °C, overlapped spectra of the first and latter spectrum were observed (Fig. 19). Signal intensity due to the species present in the higher temperature spectrum with broader line width increased with time. These results suggest that the species responsible for the spectrum observed at -30 °C converted to the species providing the spectrum observed at 60 °C. Some reaction should be responsible for such a change. Similar findings were observed for other acrylates, e.g., methyl acrylate, dodecyl acrylate, phenyl acrylate, and others. Two potential explanations for this change have been considered. One is a chain-length dependence of the spectra and the other is chemical transformation (e.g., transfer). These possibilities were examined by analysis of the ESR spectra of model radicals with various chain lengths generated from polymeric radical precursors prepared by ATRP. This analysis helped to resolve the ambiguity.

Precursors of acrylate \(\text{P}_n \ast\) with \(n = 15, 50,\) and 100 were prepared by ATRP. Polymers with calculated molecular weights and low polydispersities were obtained. The model radicals were generated by a reaction with organotin compounds and the radicals were observed by ESR spectroscopy [27]. The ESR spectrum observed for \(\text{P}_n \ast = 100\) are shown in Figure 20. The radicals provided almost the same 6-line (doublet of triplets) ESR spectra of propagating radicals present at low temperature (-30 °C) as shown in Figure 19. The observed 6-line spectra changed after raising the temperature to 60 °C, and the change in the spectrum is in agreement with the ESR spectra observed directly during the radical polymerization. The model systems do not contain any monomer and the spectroscopic change occurred without propagation. This suggests
that a chemical reaction is responsible for the observed changes. The chemical reaction
may be a chain transfer reaction from the initial
formed terminal radicals to form mid-
chain radicals as discussed earlier for radical
polymerizations of acrylates.

One additional piece of evidence supporting
the formation of a mid-chain radical was obtained
from an examination of hydrogen abstraction
from polyacrylates. This mid-chain radical can be formed by hydrogen abstraction
from polyacrylates by oxygen centered radi-
cals. PolyBA and tert-butyl peroxyde (tBPO)
dissolved in benzene, under irradiation
the mixture gave the ESR spectra shown in
Figure 21. The spectrum was very similar to
both the spectra observed in the polymeriza-
tion system (Fig. 19) and that reported by
Westmoreland et al [40]. Furthermore, it was
convincingly simulated by consideration of the
structure of two sets of methylene protons in
restricted rotation at both sides of the mid-
chain radical, as shown in Figure 22. Consequently, the radical observed at high
temperatures (Fig. 19) is due to formation of
mid-chain radicals.

A 1,5-hydrogen shift to form a mid-chain
radical has previously been considered for rad-
cal polymerization of acrylates [36-40]. Yamada et al. observed ESR spectra similar to
those in Figures 19 and 21, and reported that
the spectra were due to a mixture of propagat-
ing and mid-chain radicals [38,39]. However,
there has been no clear experimental evidence or clear explanation for the formation of the mid-chain radicals.

Here, a clear interpretation of the ESR spectra of propagating (Fig. 23a) and mid-chain radicals (Fig. 23b) was demonstrated with the aid of molecules prepared by ATRP. The proposed mechanism for the 1,5-hydrogen shift is shown in Figure 24. Formation of a six-membered ring enables the radical to migrate to the monomer unit two units before the terminal unit. Since this shift needs at least linked three monomer units, it suggests that mid-chain rad-
cal cannot be formed from a dimeric radical. A dimeric radical precursor was isolated from
a mixture of oligomeric radical precursors, and the ESR spectrum of the dimeric radical was measured. The ESR spectra of the dimeric model radical showed no change even at rela-
tively high temperature (40 °C). From the same mixture of oligomers, a mixture of oligomers, with tetracer to hexamer (4-6
monomer units) was also separated and radi-
cals were generated from the oligomers. The
ESR spectra of the mixture of radicals showed
overlapped spectra from two separate spectra
from the beginning of the reaction. This
absence of chain length dependence and no
changes for the dimer strongly suggest a for-
mation of mid-chain radicals in radical poly-
merizations of acrylates via a 1,5-hydrogen
shift reaction.

It is known that polyacrylates prepared by
conventional radical polymerization procedure
have many branches [41, 42]. An ESR study has now provided direct evidence for the ori-
gin of the branching. It should be also noted
that an estimate of $k_p$ for acrylates is difficult
by ESR which would provide the sum of the
concentration of the much more active growing
terminal radicals and less active mid-chain
radicals.

Clarification of Mechanism of Radical Migration using Uniform Oligomeric Model Radicals

Since changes from low temperature spec-
trum to the one at higher temperature were
clearly observed, even in model radical sys-
tems with fixed chain lengths, the possibility
of chemical transformation remained. The
ambiguity was solved by ESR spectroscopy of
several purified oligomeric model radical pre-
cursors prepared by ATRP. GPC elution dia-
agrams of model radical precursors of dimer,
trimer, tetracer, and pentamer are shown in
Figure 25 along with the GPC of a mixture of
the oligomers. As shown in the figure, separa-
tion and purification of the oligomers were
successful. Model radicals with clearly defined
structures were generated by the reaction of
the corresponding alkyl bromides (H-ethyl
acrylate (EA)- BA-Br, H- EA- BA-Br, H-
EA- BA-Br, H- EA- BA-Br, H- EA- BA-Br)
with an organotin compound under irradiation. The resulting radicals had struc-
tures of hydrogenated radicals, i.e., H- EA-
bA•, H- EA- BA•, H- EA- BA•, and H- EA- BA•.
Each of these radicals was investigated by ESR spectroscopy at various temperatures. Clear well-resolved spectra were observed and
precise values for hyperfine coupling constants
were determined from the spectra.

The ESR spectrum of the dimeric radical (H-
EA- BA•) showed a doublet of triplets in each
spectrum taken at various temperatures within
the range of -30 to +150 °C. The doublet and
triplet can reasonably be considered to be due
to the splitting from the α-proton and two
equivalent β-methylene protons, respectively.
Nothing happened to the dimeric radical even
at higher temperatures (Fig. 26). On the other
hand, model trimeric and tetrameric radicals
showed a clear temperature dependent irre-
versible change, as discussed below.

In the case of the model trimeric radical (H-
EA- BA- BA- BA•), the spectrum observed at -30
°C (Fig. 27) was very similar to that of the
dimeric radical. This spectrum is ascribed to a
chain end radical as shown in the figure. ESR
spectra were measured every 30 degrees as the
temperature was increased from -30 °C to 120
°C. As the temperature was raised, the spec-
trum gradually and irreversibly changed to a
different one. From 0 °C to 60 °C, the observed spectra were attributed to two kinds of overlapping spectra. The change was com-
plete at 120 °C. The resulting spectrum, observed at higher temperatures, was totally
different from that at lower temperatures (Fig.
27). When a 1,5-hydrogen shift occurs, the

![Figure 25](image-url) SEC elution diagram of purified dimer, trimer, and tetracer of BA as uniform radical precursor along with that of mixture of oligomers (before purification).

![Figure 26](image-url) ESR spectra of dimeric model radical of BA at 30 °C and 90 °C in toluene (measurement condition; modulation: 100 kHz, 0.05 mT, time constant: 0.03 sec, sweep time: 15
mT/4 min).
radical should migrate from one end to the other end of the trimeric model radical as shown in Figure 27. The spectrum can be simulated using the hyperfine splitting constants shown in the figure. The most important feature of this simulation is a small triplet that appeared in each spectroscopic line. When this trimer was prepared by ATRP, ethyl 2-bromo propionate was used as the initiator and the initiator fragment was counted as first monomer unit. So, we only had an ethyl ester group at the other chain end. The presence of a small triplet clearly indicates that the radical is located on the first ethyl acrylate unit. Consequently, we can say that the radical migrated from one end to the other end of the trimer.

A similar ESR study was done for the tetrameric model radical (H-EA-BA-BA-BA). The ESR spectra at -30 °C and 120 °C are shown in Figure 28. The low temperature spectrum, observed at -30 °C, was very similar to those from the dimeric and trimeric model radicals. A similar irreversible spectroscopic change took place, as in the case of the trimeric model radical, at higher temperatures. However, the final spectrum was different from that of the trimeric model radical. In the case of a tetrameric model radical, a 1,5-hydrogen shift would cause transfer of a radical from the chain end to the first rBA unit, which is located two units before the other end unit, through a six-membered ring structure (Fig. 28). The transferred radical should have mid-chain type structure with methylene groups at both sides (H-EA-rBA(•)-BA-BA-H). The spectrum of the radical at 120 °C shown in Figure 28 is ascribable to such a mid-chain radical. These findings provide clear experimental evidence of a 1,5-hydrogen shift at the propagating chain end of acrylate radical polymerizations.

A pentameric model radical was also generated and observed by ESR and a similar temperature dependent spectroscopic change to those seen in the case of the trimer and tetramer was observed. The resulting high temperature spectrum is very similar to those observed in polymeric acrylate radicals. These findings strongly suggest that the mechanism of the chain transfer reaction in an acrylate radical polymerization is a 1,5-hydrogen shift that occurs through a six-membered ring structure. Formation of a six-membered ring is a kinetically favored process and the transfer occurred from a secondary radical to form a thermodynamically more stable tertiary radical. One further piece of information can be obtained from the result of the pentamer which has H-EA-BA-BA-BA-BA•.

When the ESR spectra obtained by direct detection in a radical polymerization processes are compared with those of model radicals generated from well defined radical precursors prepared by ATRP, it is easier to understand what happens at each step of the elementary processes involved in radical polymerizations. This information helps define the reaction mechanisms, which otherwise have been speculated upon without direct experimental evidence. ESR spectroscopy has provided unambiguous proof of the process for several reactions involved in radical polymerization with...
the aid of materials prepared by controlled radical polymerization techniques. In general this approach can be applied to any chemical reaction not only to a radical reaction, which has well-defined starting materials and final products but ambiguous intermediate products.

Research using uniform oligomeric model radicals provides the possibility for expansion of the research field. In general, precise quantum chemical calculations are difficult to apply for polymeric radicals with long chain lengths but theoretical calculations can be conducted for such small radicals. The small radicals can provide highly resolved ESR spectra and they can provide precise values of hyperfine splitting constants. Polymeric radicals usually show larger line width making the precise determination of the splitting constants more difficult. The values are strongly related to electronic nature of the radicals and can be evaluated by the results of the calculations. ESR itself is a quantum mechanical phenomenon. The combination of ESR, ATRP, and theoretical calculations lead the way to study of a deeper connection between experimental results and theoretical calculations.

It was also essential to examine and quantify some intermediates in ATRP, to provide a deeper understanding of the ATRP process, including identification of the structure and concentration of the paramagnetic species involved in the process [14, 30, 43-48]. Although it is very interesting and important for investigation of ATRP, the structural features of the paramagnetic transition metal compounds will not be discussed in this paper.

Experimental

Monomers, initiators, copper salts, and ligands were purified in the usual manner. Presence of carbon-bromine terminal groups and chain lengths of the radical precursors were checked by measurements of Electron Spray Ionization (ESI) mass spectra. Generation of model radicals from precursors was conducted by a reaction with an oxygen-free argon-argon und journalist irradiation. ESR spectra of radicals were recorded on a JEOL JES RE-2X spectrometer operating in the X-band, utilizing a 100 kHz field modulation, and a microwave power of 1 mW. A TE011 mode universal cavity was used. Measurement temperature was controlled by JEOL DVT2 variable-temperature accessory. ESR measurements were mainly performed in molybdenum at 150 and 120 °C and in toluene at 90, 60, 30, and -30 °C. Spectroscopic simulations were carried out by JEOL IRPT Data Analysis System. Molecular weights and molecular weight distributions were roughly estimated using a TOSOH CCP&8020 series GPC (SEC) system with TSK-gel columns. Polystyrene standards were used to calibrate the columns.

Acknowledgements

The author is grateful to Professor Emeritus Mikiharu Kamachi, Osaka University, for his kind advice and discussions on ESR study of radical polymerizations. The author wishes to thank Professor Masahiro Kohno, Tohoku University, for his valuable technical guidance in ESR spectroscopy. Sincere thanks are also due to Professor Krzysztof Matyjaszewski, Carnegie Mellon University, for his kind suggestions and continuous encouragements. The author wishes to express his gratitude to Dr. James Spanswick, Carnegie Mellon University, for reading the manuscript and making a number of helpful suggestions and comments.

References

Introduction
The JIB-4500 is a multifunctional MultiBeam System that combines both a high-resolution SEM (scanning electron microscope) and a high-performance FIB (focused ion beam) into one chamber. It enables you to perform cross-sectional milling, SEM observation, and X-ray analysis in one instrument. In this paper, a brief overview of the instrument and its applications are given.

Features of JIB-4500
The JIB-4500 is a MultiBeam System that incorporates a SEM equipped with a high-brightness LaB₆ electron gun and a high-performance FIB in one chamber. Figure 1 shows the appearance of the JIB-4500 and Table 1 lists its principal performance. This instrument can perform SEM observation and various analyses such as EDS (energy dispersive spectroscopy), without exposing a specimen to the atmosphere after cross-sectional milling by FIB. This feature offers not only greatly reduced experiment time but also observation and analysis of the specimen with an uncontaminated surface, because the surface of the specimen is not exposed to the atmosphere. Thus, this instrument is very useful for obtaining true specimen information. Figure 2 shows SEM images (BEI: backscattered electron image and SEI: secondary electron image), an SIM (scanning ion microscope) image and EDS analysis results of a chip capacitor subjected to cross-sectional milling. In addition, this instrument allows live monitoring of SEM BEI collected by a backscattered-electron detector during the specimen milling with an ion beam. This capability enables you to stop milling at a suitable depth. Figure 3 shows an example of live monitoring of cross-sectional milling applied to silver wax.

Furthermore, a special feature of this MultiBeam System is a function that mills the specimen multiple times at a constant step, and automatically acquires SEM images for every step (S₃™: Serial Slicing and Sampling). The use of this innovative function enables you to intuitively grasp the accurate three-dimensional (3D) structure of the specimen. Moreover, using a 3D reconstruction software program, a 3D reconstructed image can be created. S₃™ is particularly useful because this function can be applied to a relatively large structure with a thickness from several micrometers to several tens of micrometers, which is difficult to analyze by TEM Tomography. Figure 4 shows sequential SEM BEIs obtained by S₃™ and reconstructed images of silver wax. Figure 5 shows sequential SEM SEIs and reconstructed images of pollens of pine, which are obtained in the same manner as shown in Fig. 4.

The JIB-4500 incorporates a large specimen stage that accommodates a specimen with a diameter up to 76 mm. Table 2 shows the performance of the specimen stage. To make various analysis applications possible, the JIB-4500 is provided with attachment ports for EDS, EBSD (electron backscatter diffraction), CLD (cathodoluminescence), etc.

Conclusion
The JIB-4500 MultiBeam System enables efficient FIB cross-sectional milling, SEM observation, and various analyses such as EDS analysis. This instrument is very useful for a wide variety of applications, including material analysis, failure analysis of electronic parts, and specimen preparation for SEM and TEM.

Table 1  Principal performance of the JIB-4500.

<table>
<thead>
<tr>
<th></th>
<th>FIB</th>
<th>SEM</th>
</tr>
</thead>
<tbody>
<tr>
<td>Emitter</td>
<td>Ga liquid-metal ion source</td>
<td>LaB₆</td>
</tr>
<tr>
<td>Accelerating voltage</td>
<td>1 to 30 kV (steps)</td>
<td>0.3 to 30 kV (steps)</td>
</tr>
<tr>
<td>Magnification</td>
<td>× 30, × 100 to 300,000</td>
<td>× 5 to 300,000</td>
</tr>
<tr>
<td>Image resolution</td>
<td>5 nm (at 30 kV)</td>
<td>2.5 nm (at 30 kV)</td>
</tr>
<tr>
<td>Maximum probe current</td>
<td>30 nA (at 30 kV)</td>
<td>1 µA (at 30 kV)</td>
</tr>
</tbody>
</table>
Table 2  Performance of the JIB-4500 specimen stage.

<table>
<thead>
<tr>
<th>Movement range</th>
<th>X (mm)</th>
<th>Y (mm)</th>
<th>Z (mm)</th>
<th>Fine Z (mm)</th>
<th>Tilt (deg)</th>
<th>R (deg)</th>
<th>Maximum specimen size (mm)</th>
</tr>
</thead>
<tbody>
<tr>
<td></td>
<td></td>
<td></td>
<td></td>
<td>4</td>
<td>-5~60</td>
<td>360</td>
<td>76 Ø</td>
</tr>
</tbody>
</table>

Fig.2 SEM images (BEI and SEI), an SIM image and EDS X-ray mapping results of a chip capacitor subjected to cross-sectional milling. A specimen can be imaged with SEM and analyzed immediately after it is subjected to cross-sectional milling by FIB.

Fig.3 SEM (BEI) enables real-time observation of the FIB-milling state.

Fig.4 Automatically acquired SEM BEIs obtained by S3™ at constant steps, and reconstructed images based on these SEM images (specimen: silver wax).

Fig.5 Sequential SEM SEIs acquired by S3™ and reconstructed images in the same manner as shown in Fig.4 (specimen: pollens of pine). This function is useful for biological specimens.
High Power Electron Beam Source Used for Melting Metal Materials

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Industrial Equipment Division, JEOL Ltd.

Introduction

The JEBG-3000UB High Power Electron Beam Source produces a high-power electron beam with a maximum beam output of 300 kW, thus the JEBG-3000UB is used for melting and purifying metal materials. In this paper, an example of applying the JEBG-3000UB High Power Electron Beam Source to the production process of polycrystalline Si, and the features of the JEBG-3000UB are described.

Solar Cell

Photovoltaic power generation has been drawing much attention as clean, recyclable energy, and various materials are studied for this power generation. These materials are divided roughly into three categories, silicon, compound semiconductor and organic material. Table 1 shows conversion efficiencies for each category and their features [1].

The solar cell using crystalline Si has a high conversion efficiency of 13 to 18%, and also has a long service life of 30 years. Thus, the solar cell dominates about 80% of the total production of photovoltaic power generation.

Supply of Polycrystalline Si Materials

The production capacity of polycrystalline Si materials in the world, including those for semiconductors, is about 40,000 tons per year. This worldwide production capacity is predicted to be more than 100,000 tons in 2010, as shown in Fig. 1 [2], [3]. It should be noted that the production capacity in 2007 and subsequent years is an estimate that totals production increases announced in the production plans of semiconductor material companies.

Although a high purity of eleven nines (99,999999999%) is required for Si materials for the semiconductor industry, as for Si materials for the solar cell, a purity of six nines (99,999%) is enough.

As typical production methods of polycrystalline Si materials, the Siemens method and the melted Si purification method are described.

Siemens method

This method first vaporizes Si metal (purity: 99%) to generate trichlorosilane (SiCl3), and finally purifies Si. Then, the Si is solidified again [4-6]. The procedure is as follows.

1) Si metal and hydrochloric acid (HCl) are reacted to produce liquid trichlorosilane (SiCl3).
2) Distillation and purification of trichlorosilane are repeated to highly purify it.
3) In a deposition chamber (Fig. 2), a Si rod is heated to about 1000 °C. By passing trichlorosilane (SiCl3) and hydrogen through the chamber, high-purity polycrystalline Si is deposited on a Si rod. As a result, Si with a high purity of eleven nines is obtained.

Melted Si purification method

The melted Si purification method developed by the NEDO project is described [6], [7]. In this method, Si metal (purity: 99%) is used as a starting material. While Si is kept in the solid phase, impurity elements contained in the Si are removed and Si for solar cells is produced. Si with a purity of six nines is obtained. Although the purity of the Si is low compared with the purity obtained by the Siemens method, the melted Si purification method has several advantages. That is, the energy needed to produce Si is very low, and the capital investment for the production of Si materials can be held down to a low level.

To be more precise, the melted Si purification method consists of the first process and the second process. The first process includes phosphorous (P) removal and rough removal of metal impurities, and the second process...
Table 1  Conversion efficiencies and features of various solar cells.

<table>
<thead>
<tr>
<th>Typical category</th>
<th>Power generation efficiency (%)</th>
<th>Main features</th>
</tr>
</thead>
<tbody>
<tr>
<td>Silicon system</td>
<td></td>
<td></td>
</tr>
<tr>
<td>Polycrystal type</td>
<td>13 -17</td>
<td>For mass production</td>
</tr>
<tr>
<td>Single-crystal type</td>
<td>16 -18</td>
<td>High conversion efficiency</td>
</tr>
<tr>
<td>Ribbon</td>
<td>16</td>
<td>Slice process not required</td>
</tr>
<tr>
<td>Thin film type</td>
<td>7 -12</td>
<td>Deposition with low temperature, large area, and multi-layers is possible.</td>
</tr>
<tr>
<td>Compound semiconductor</td>
<td></td>
<td></td>
</tr>
<tr>
<td>Single-crystal type (GaAs)</td>
<td>30 -40</td>
<td>High conversion efficiency</td>
</tr>
<tr>
<td>Polycrystal type (CIGS,CdTe)</td>
<td>13</td>
<td>High cost</td>
</tr>
<tr>
<td>Organic system</td>
<td></td>
<td></td>
</tr>
<tr>
<td>Dye-sensitization type</td>
<td>6</td>
<td>Vacuum and high-temperature process not required</td>
</tr>
<tr>
<td>Organic thin film type</td>
<td>4</td>
<td>Low cost is possible. Research-and-development stage</td>
</tr>
</tbody>
</table>

Fig.1 Production capacity of polycrystalline Si in the world.
(Source : RTS Corporation)

Fig.2 Schematic diagram of Siemens method.

Fig.3 Process and schematic diagram of melted Si purification method.
includes boron (B) and carbon (C) removal, and finish removal of metal impurities (Fig. 3).
P removal is performed by the electron beam vacuum-melting method. Si metal is irradiated with a high-power electron beam, and the Si metal is dissolved. Depending on the difference of vapor pressure, P is vaporized preferentially and the purity of Si is raised.

**JEOL 300 kW High Power Electron Beam Source**

The JEBG-3000UB 300 kWa High Power Electron Beam Source, developed by JEOL, is used for the purification of polycrystalline Si materials for solar cells by means of the melt-Si purification method. Figure 4 shows the appearance of the JEBG-3000UB.

**Specifications**

Table 2 shows the specifications for the JEBG-3000UB [8]. The maximum beam output is 300 kW (at an accelerating voltage of 40 kV and a maximum emission current of 7.5 A).

<table>
<thead>
<tr>
<th>Specification</th>
<th>Value</th>
</tr>
</thead>
<tbody>
<tr>
<td>Maximum output</td>
<td>300 kW(-40 kV, 7.5 A)</td>
</tr>
<tr>
<td>Accelerating voltage</td>
<td>-40 kV</td>
</tr>
<tr>
<td>Electron-beam scan width</td>
<td>+/-500 mm</td>
</tr>
<tr>
<td>Scanning coil</td>
<td>Two axes (X, Y) (X and Y orthogonal)</td>
</tr>
<tr>
<td>Dynamic focusing lens</td>
<td>Option</td>
</tr>
<tr>
<td>Astigmatism correction coil</td>
<td>Option</td>
</tr>
<tr>
<td>Corresponding power supply</td>
<td>JEOL JST-300C</td>
</tr>
</tbody>
</table>

**Structures and features**

Figure 5 shows the electron optical system of the High Power Electron Beam Source. This electron optical system is roughly divided into three systems.

1. The illumination system consisting of a filament, a tungsten (W) cathode, a Wehnelt, and an anode.
2. The imaging system consisting of the 1st lens and the 2nd lens.
3. The scan system consisting of a dynamic focusing lens, an astigmatism correction coil, and an X/Y deflection coil.

The bombardment method is employed for the illumination system. The bombardment method generates thermoelectrons with heating of a filament, heats a disk-shaped W cathode, and then generates an electron beam from the W cathode. This bombardment method is superior to the filament method, in terms of the following three points.

(a) An electron beam with higher current density is obtained, (b) The emission of electrons from the surface of the cathode makes it possible to more sharply focus the electron beam, and (c) In the filament method, the filament is directly suffers from ion bombardment, thus it is likely to burn out. In the bombardment method, since the cathode is disk-shaped, it can work for long periods of time.

In addition, a grid-assembly construction of the filament and W cathode leads to one unit.
geometry, thus simplifying the positioning and maintenance of the illumination system.

The imaging system has a function to focus the electron beam onto the surface of a material, by means of two lenses of the 1st lens and the 2nd lens. The scan system performs electron beam scan by means of the X/Y deflection coil. In addition, a dynamic focusing lens and an astigmatism correction coil have functions which respectively correct a focus shift and the shape of the electron beam, during the beam scanning.

Furthermore, the JEBG-3000UB has various scan control parameters to effectively operate as a high power electron beam source. **Figure 6** shows these parameters, including the control parameters for the amplitudes in the X direction (XA), those for the amplitudes in the Y direction (YA), those for rotations in the X and Y directions (X-ROT, Y-ROT), those for dwell time (DT), and those for the beam shape.

**Figure 7** shows examples of various scans performed by the JEBG-3000UB, presenting line scan, X-ROT added to line scan, and YA added to line scan. The JEBG-3000UB enables such a variety of scans, making it possible to uniformly dissolve surfaces of materials.

**Figure 8** presents the image of applications of the JEBG-3000UB High Power Electron Beam Source to purification of polycrystalline Si materials (P removal).

**Conclusion**

As described above, the JEBG-3000UB has various features suitable for the production of polycrystalline Si materials. By exploiting these features, it is expected that the JEBG-3000UB will contribute to expanding the applications of solar cells.

**References**

Introduction of New Products

MultiBeam System
JIB-4600F

The newly developed JIB-4600F MultiBeam System unites the unique imaging and analytical capabilities of the High Power Optics employed in the TFE SEM and a high-performance FIB column in a highly efficient and powerful system. Together with the advanced software developed at JEOL, the JIB-4600F offers an easy-to-use tool for highly automated sample preparation combined with high-resolution imaging and sub-micron analysis of the specimen cross-section. This tool will help to significantly reduce the time it takes to find the answer for various research and industrial applications requiring materials and defect analysis.

Observation and Analysis
The High Power Optics developed for cross-section nanostructure characterization provides the guaranteed resolution of 1.2 nm at 30 kV, making observation at magnification higher than ×100,000 easily achievable which is important for process monitoring and defect identification. The JEOL patented High Power Optics is rated to produce a probe current up to 200 nA while maintaining a small probe size. The High Power Optics is suitable for a wide range of applications even at a low accelerating voltage. Under these conditions, the JIB-4600F MultiBeam System can offer enough current even when running the FIB process.

Processing
The newly developed high-performance FIB column achieves high-throughput milling with a beam current of 30 nA at 30 kV, to offer a substantial increase in productivity. It provides a stable and small ion probe even in the high current mode. The rapid scan mode makes preparation of thin TEM or bulk SEM samples an easy task with high-throughput rough pre-processing. The processing recipe mode offers various settings for process shape, ion beam diameter and ion beam dose at each gas deposition, rough pre-processing and final precise processing.

In addition, the processing recipe helps to guarantee high reproducibility and reliability of results during the preparation of thin TEM samples, making it possible to repeatedly provide specimens having the same shape. The JIB-4600F offers a three-dimensional reconstruction application called S³TM (Serial Slice and Sampling). Based on the unique features of the JEOL 3D system developed for TEM tilt series acquisition and reconstruction, the S³TM module provides depth profile images for the sample cross-section in automatic serial processing mode.
Introduction of New Products

Electron Probe Microanalyzer

JXA-8230

The JXA-8230 is a newly developed Electron Probe Microanalyzer (EPMA). EPMA is an instrument that illuminates the specimen with an accelerated and finely focused electron beam (electron probe), and measures the wavelengths and intensities of characteristic X-rays, as well as the quantities of secondary and backscattered electrons from the specimen. This capability makes it possible to nondestructively analyze the specimen from micro to macro areas, with including constituent elements, concentrations, element distribution, surface morphology and mean atomic number.

The JXA-8230 achieves an integrated control of its various components using a personal computer: wavelength-dispersive X-ray spectrometers (WDS), an energy-dispersive X-ray spectrometer (EDS), an electron optical system, a specimen stage, etc. This sophisticated integration makes the JXA-8230 a state-of-the-art, hybrid EPMA, which enables you to perform measurement utilizing the features of each detector and compile versatile data as analysis results.

Features

Performance improvement in X-ray dispersion
Newly developed analyzing crystals are available. These are effective for very light element analyses and suitable for CHIME (Chemical Th-U-total Pb isochron method) age dating. You can combine these crystals with an optional panchromatic cathodoluminescence detector or an optional CHIME age dating program.

Efficient data acquisition
The JXA-8230 incorporates advanced analysis programs for line analysis and mapping, enabling simultaneous acquisition of electron images (SEI, BEI), WDS (up to five signals) and EDS signals of all detected elements, by means of either electron-probe scanning or specimen-stage scanning. In addition, the JXA-8230 can make use of the "EDS Active Map" function even during simultaneous measurement with multiple WDSs. Furthermore, a combined use with an optional silicon-drift detector (SDD), which requires no liquid nitrogen, enables you to easily perform efficient data acquisition.

Newly designed PC-GUI (graphical user interface)
A series of operations, from observing surface morphology and elemental analysis to data processing and outputting, can be seamlessly performed in a user-friendly personal computer environment. In addition, the new GUI provides "Click Point Analysis" function for starting analysis simply by clicking on a scanning image, and "User recipe" function that enables the creation of a customized recipe for frequently used analytical conditions. With these extensive functions, various operation styles can be chosen according to the level and needs of EPMA users. Highly reliable analysis results are obtainable with easy and efficient operation.

Sophisticated SEM imaging function
Scanning images, such as secondary and backscattered electron images, are displayed in real time with high resolution of 1280×960 pixels, thus enabling you to observe still images in a bright room. In addition, since the operation device and GUI for the JXA-8230 are shared with JEOL FE-SEMs, it is convenient to acquire the skill when you already use an FE-SEM. Furthermore, in the observation of X-ray images, since you can superimpose multiple X-ray images on a scanning image in real time, you can easily search a field of view for analysis (area of interest).

Turbo molecular pump is a standard configuration.
Since a turbo molecular pump is adopted as a main pump, a clean vacuum is obtained and also, operation energy and heat exhausted to the environment can be reduced to a low level.
The scanning electron microscope (SEM) is an easy-to-use, fast characterization tool for revealing fine structures of specimens, which cannot be viewed by an optical microscope. In addition, the SEM can rapidly analyze constituent elements in specimens. Thus, the SEM is widely used in all research fields, as well as for industrial applications, ranging from development of new products to quality control. Now, requirement for SEM is much easier operation comparable to optical microscope. To adapt the SEM to versatile applications, JEOL has developed high-performance SEM series that incorporate newly designed software for easier SEM operations.

The JSM-6510 series is equipped with a general-purpose specimen chamber, which enables observation of specimens up to 150 mm in diameter. The JSM-6610 series accommodates a large-specimen chamber and a large specimen stage, for observation of specimens up to 200 mm in diameter.

You can easily search for areas of interest by taking an image of a specimen with a CCD camera and acquiring this color image into stage navigation software. An enlarged CCD image is equivalent to $\times 1$ for the JSM-6610 series, and equivalent to $\times 2$ for the JSM-6510 series. This feature enables you to view wider fields, which are difficult to see with the SEM.

SEM images provide high resolution (several hundreds of times greater than optical microscope), and also, the focal depth of SEM is several tens of times greater than optical microscope. These advantages are suitable for observation of complicated structures, enabling you to easily measure lengths and heights on specimen surfaces.

By installing an energy-dispersive X-ray spectrometer (EDS) in the SEM, you can nondestructively analyze constituent elements in a microarea down to 1 µm size while observing this small area, in a very short time. EDS-embedded analytical scanning electron microscopes (ASEM), —JSM-6510A, JSM-6510LA, JSM-6610A, JSM-6610LA— enable you to efficiently perform overall processes from observation to analysis.

To meet demand for “observation of a nonconductive specimen as it is,” low-vacuum SEMs (JSM-6510LV, JSM-6510LA, JSM-6610LV, JSM-6610LA) are available.

Furthermore, you can easily learn how to maintain the instrument using a video displayed on a SEM monitor screen, for example, the method of replacing a filament. Thus, high performance of the instrument, including a high resolution of 3 nm, can be produced anytime.
Introduction of New Products

Thermal FE SEM
JSM-7600F

The JSM-7600F, a new lineup of JEOL FE-SEM series, is a state-of-the-art thermal FE-SEM that successfully combines ultrahigh-resolution imaging with optimized analytical functionality. In addition, the JSM-7600F incorporates a large specimen chamber. This uniquely designed chamber, which accommodates a 200 mm diameter specimen, is optimized for a large variety of detectors for secondary electrons, backscattered electrons, EDS, WDS, EBSD, CL, etc.

Features
● Ultrahigh resolution comparable to the cold cathode FE-SEM.
● In-Lens Thermal FEG.
● Aperture angle control lens automatically optimizes the spot size at both high and low currents for both analysis and imaging.
● High probe current up to 200 nA (at 15 kV) for various analytical purposes (WDS, EDS, EBSD, CL, etc.)
● Built-in r-filter enabling user selectable mixture of secondary electron and backscattered electron images.
● Gentle Beam mode for top-surface imaging, reduced beam damage and charge suppression.
● Eco design for energy conservation.

MultiBeam System
JIB-4500

The JIB-4500 MultiBeam System achieves surface/internal 3D imaging and analysis with simple operation. In addition, this innovative system has optimum geometry for all functions from FIB milling, SEM observation to various analyses such as EDS, EBSD and CL.

Features
● Combining a high-resolution LaB6 SEM and a high-performance FIB.
● Multifunctional specimen chamber.
● High-sensitivity multi-imaging.
● Cross-section preparation for SEM and thin-film preparation for TEM.
● S3™ (Serial Slice and Sampling) for 3D imaging.
● Sophisticated user interface.